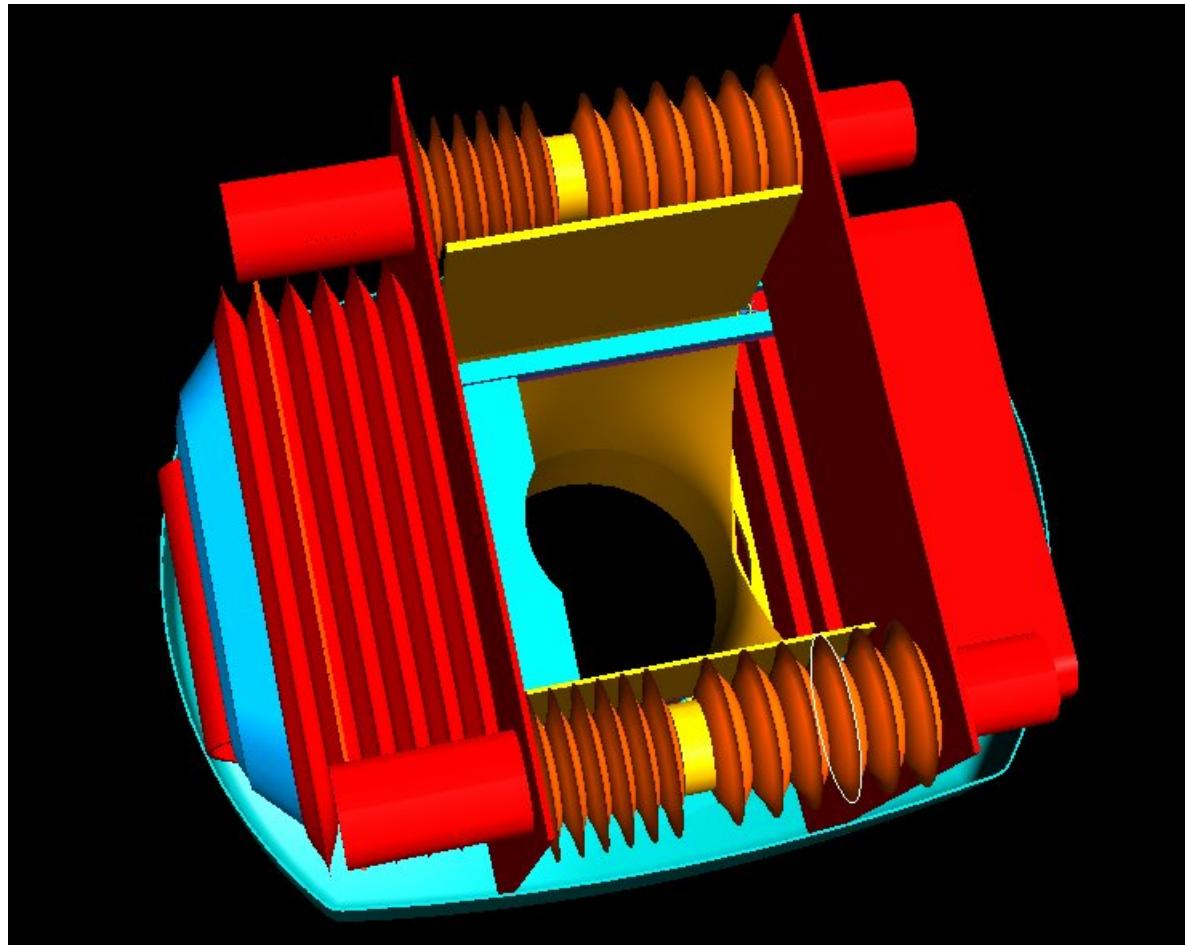
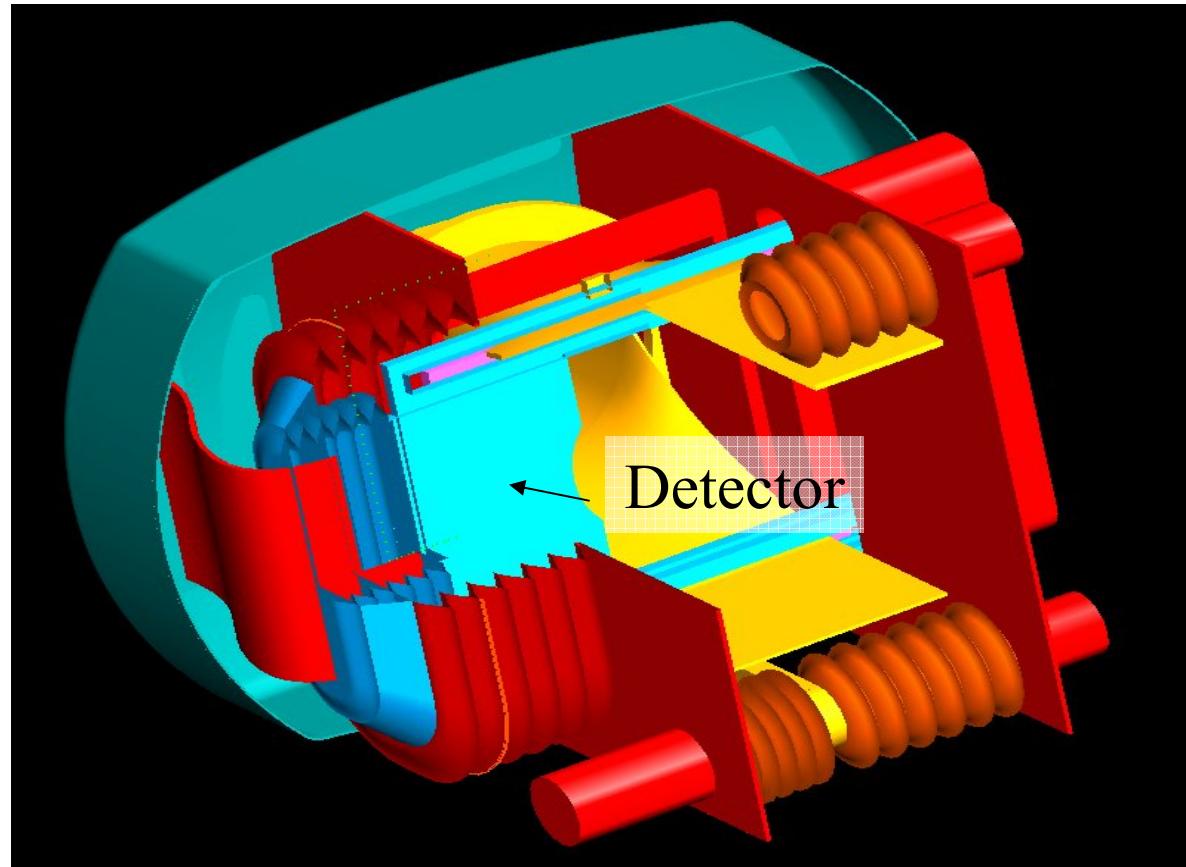


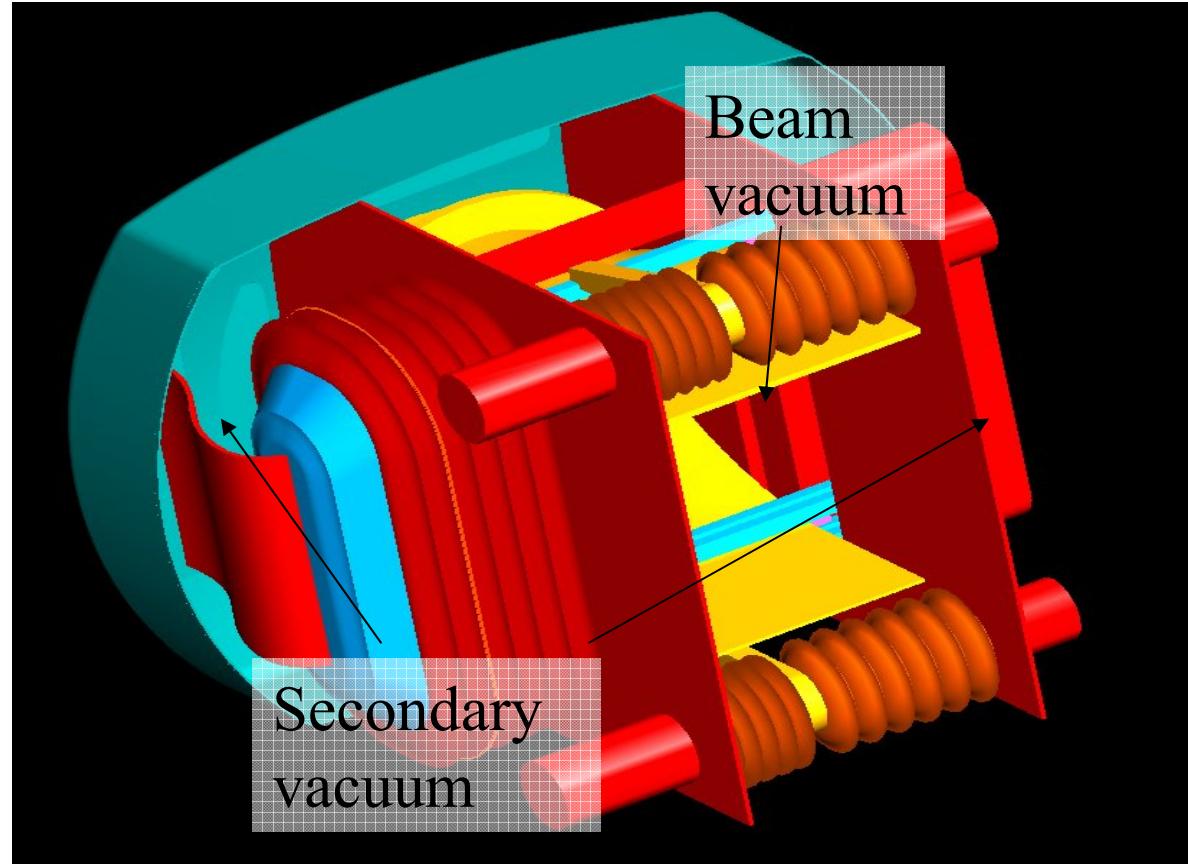
2. μ station, Secondary Vacuum Implementation



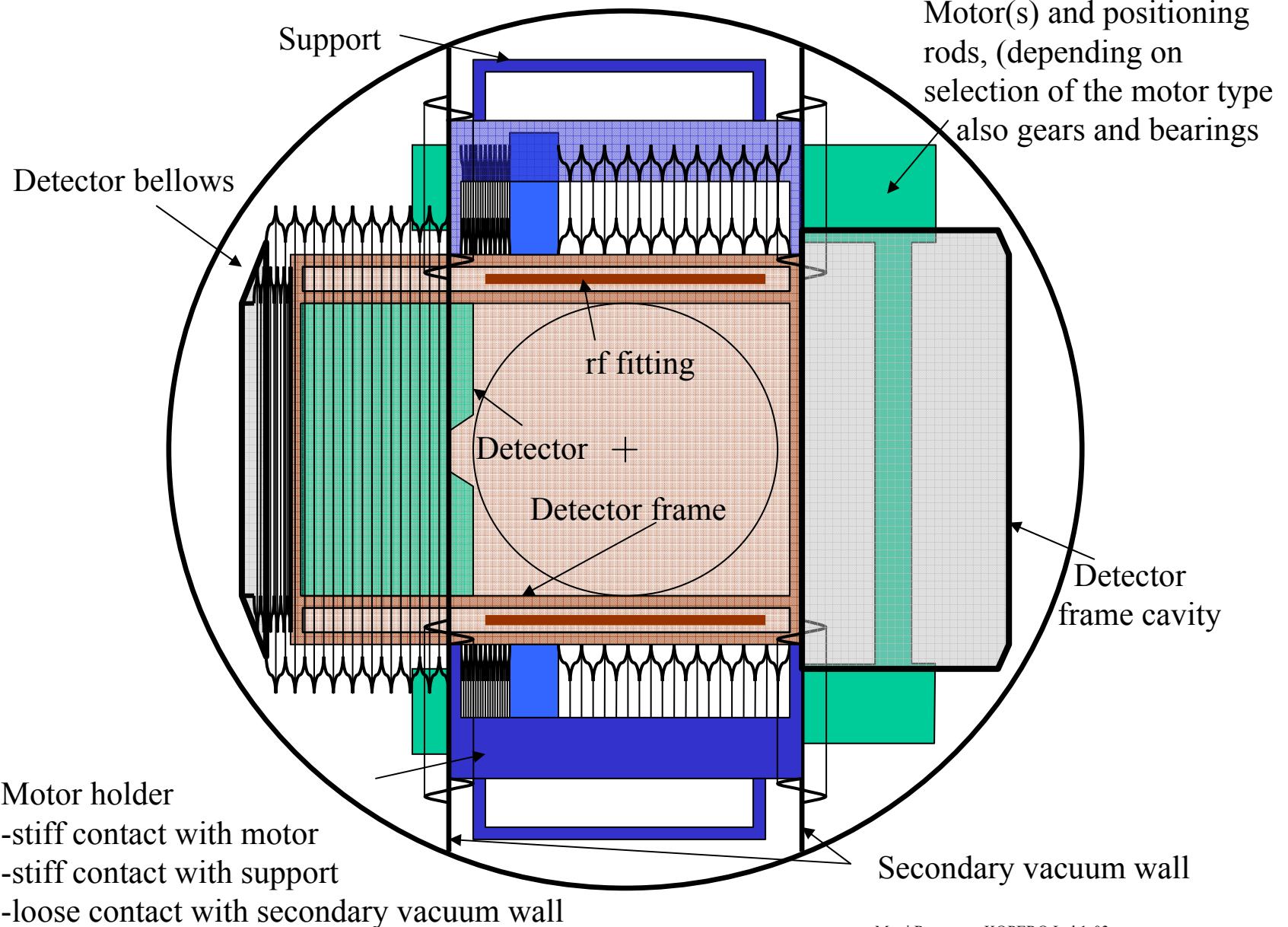
2. μ station, Secondary Vacuum Implementation



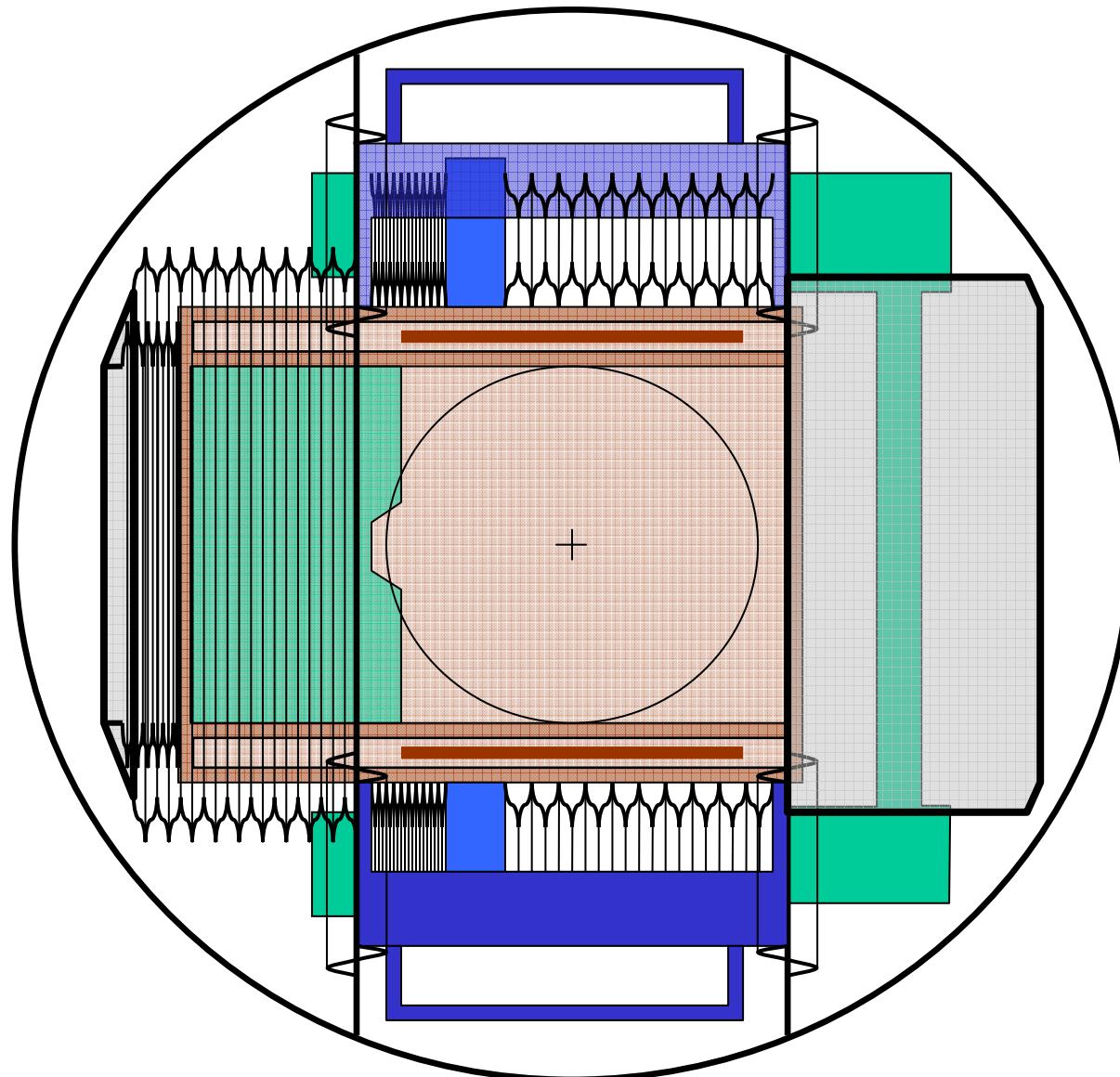
2. μ station, Secondary Vacuum Implementation



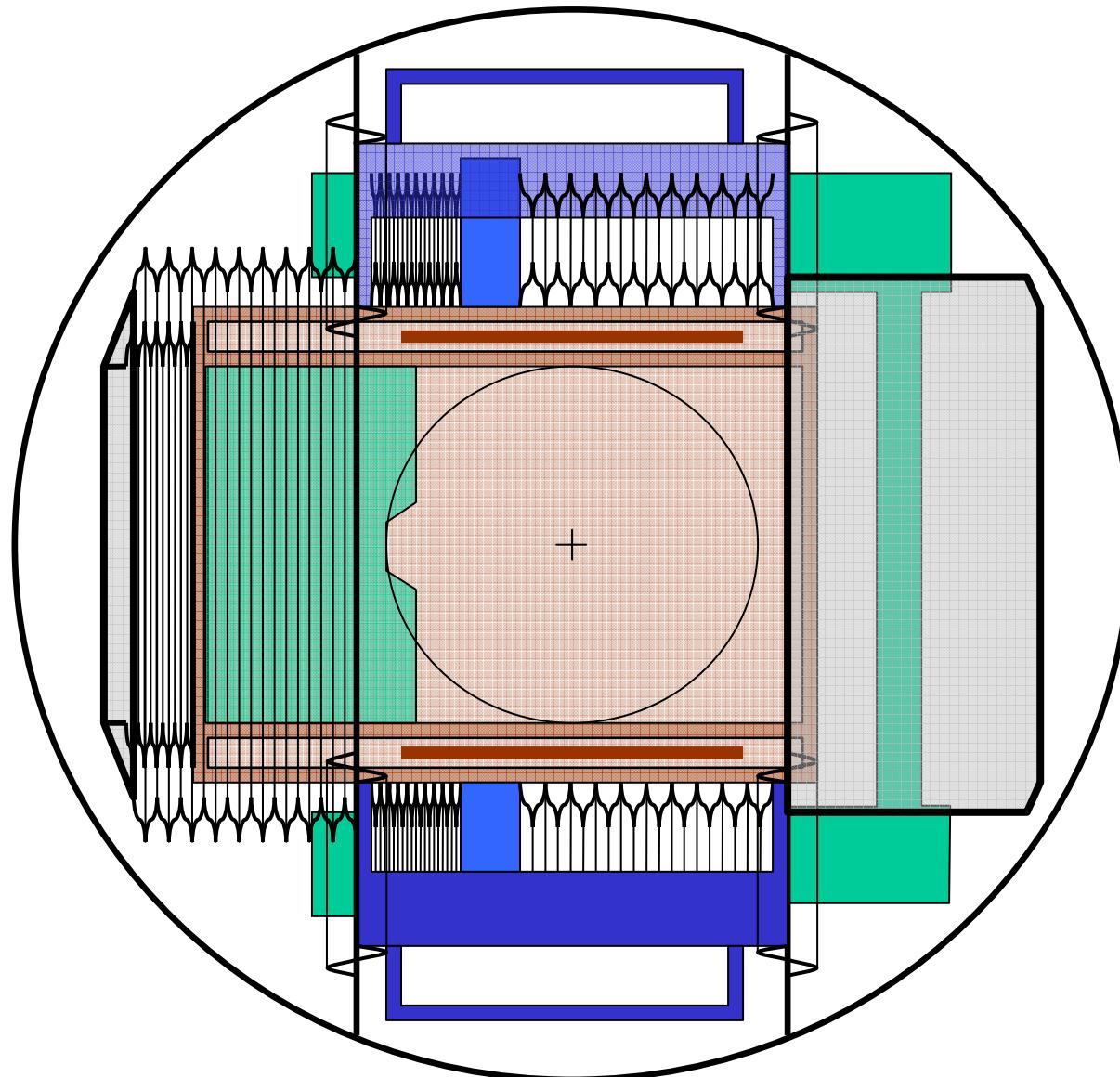
2.1. μ station, Secondary Vacuum Implementation



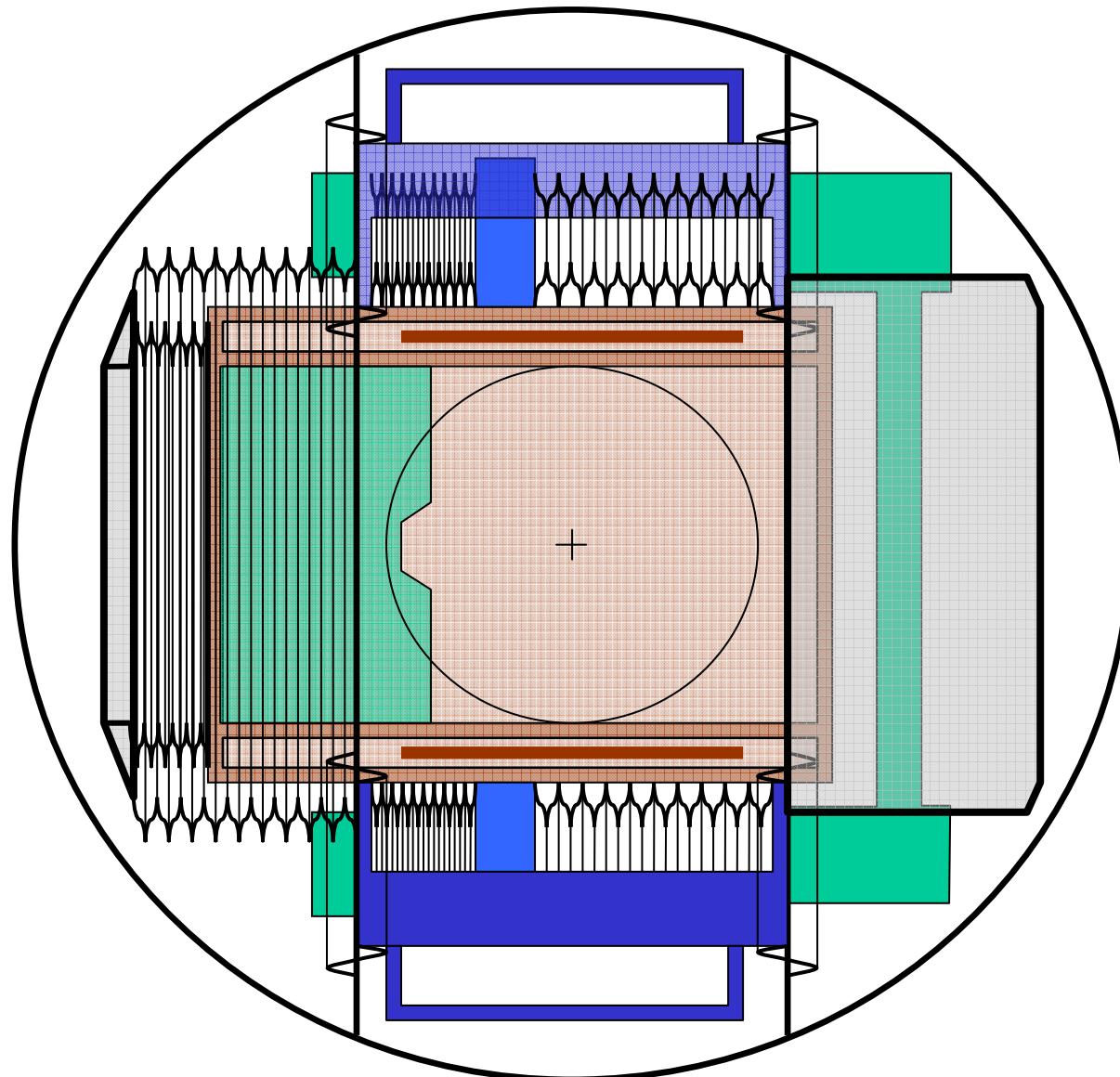
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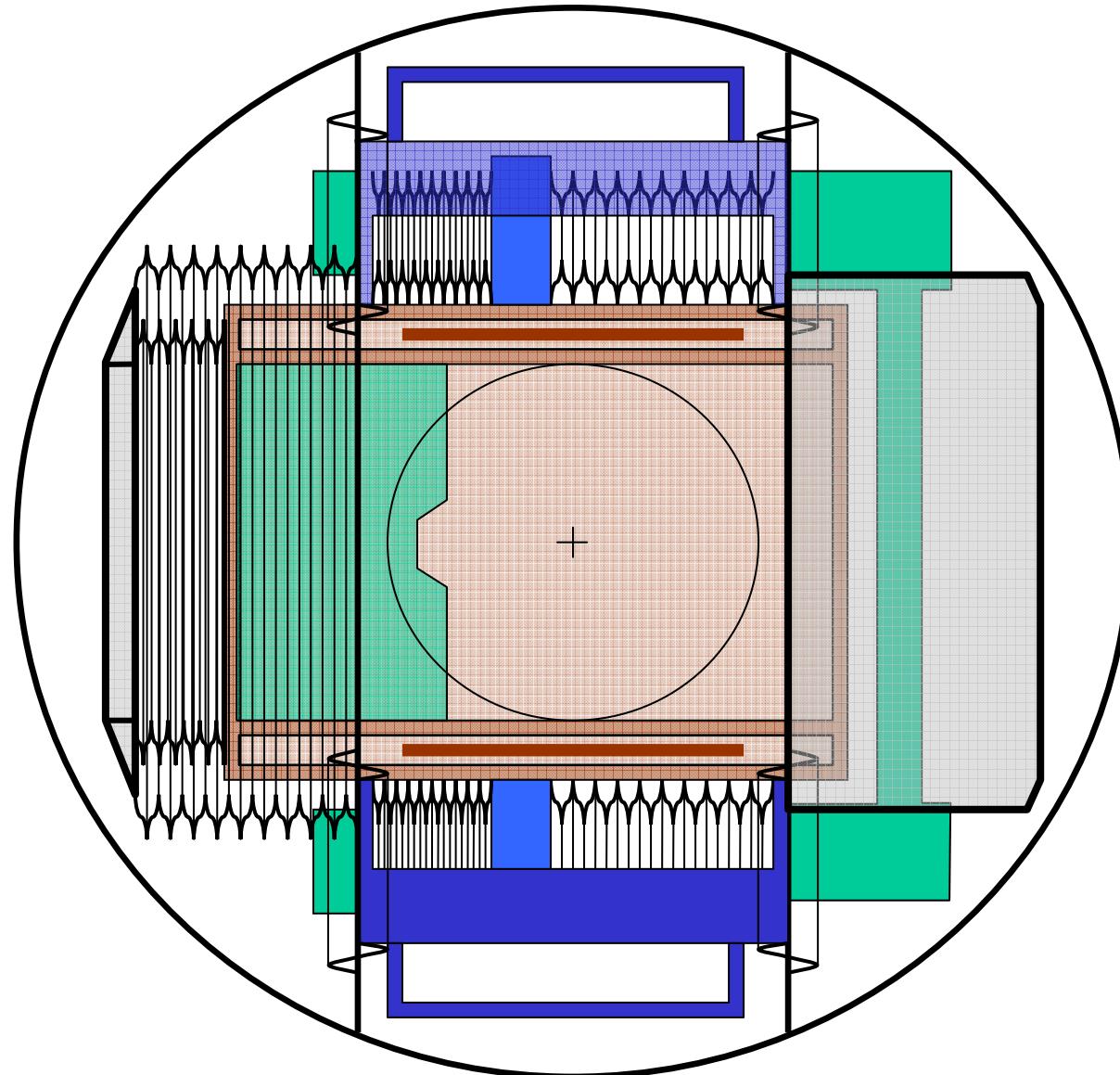
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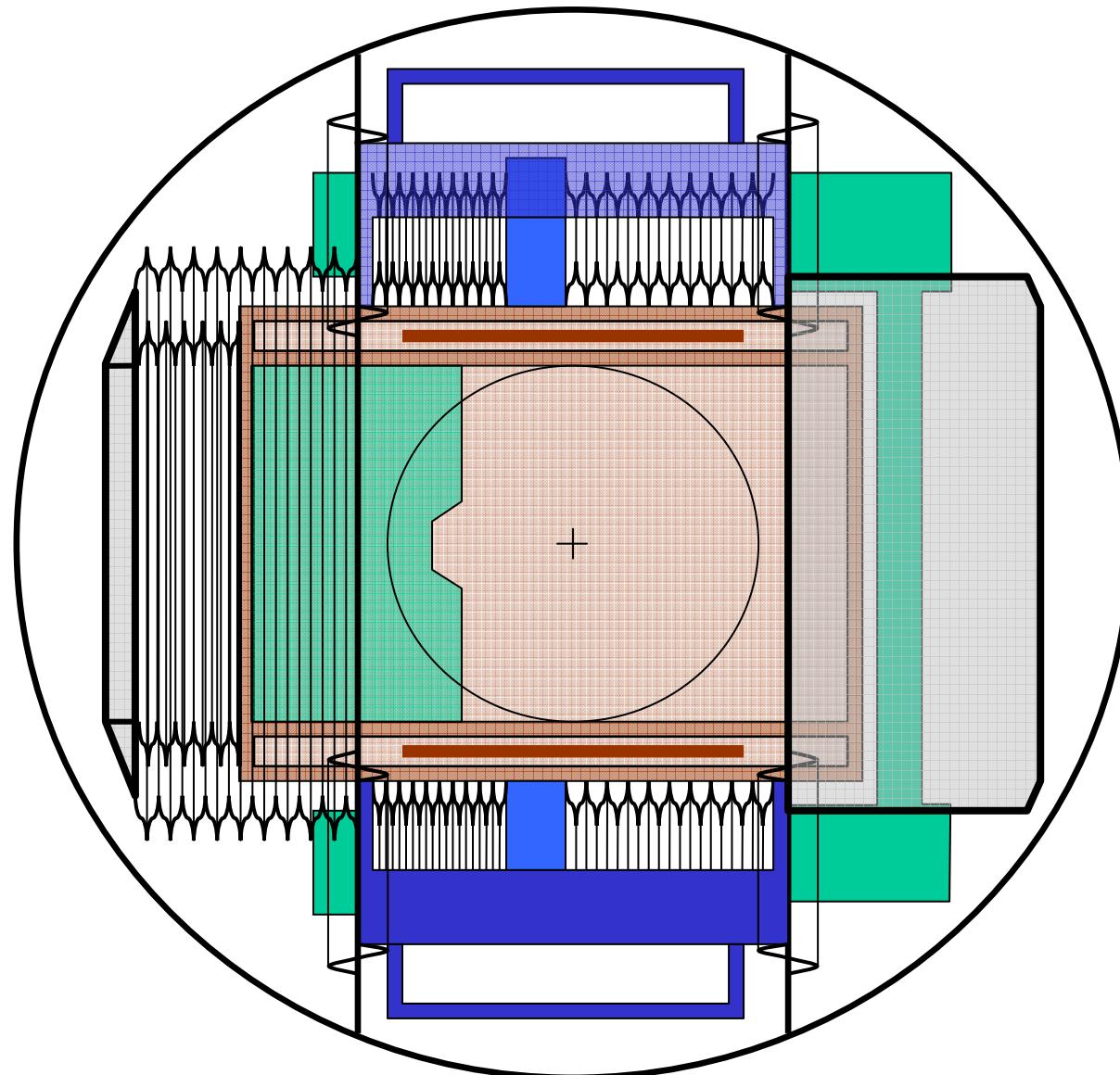
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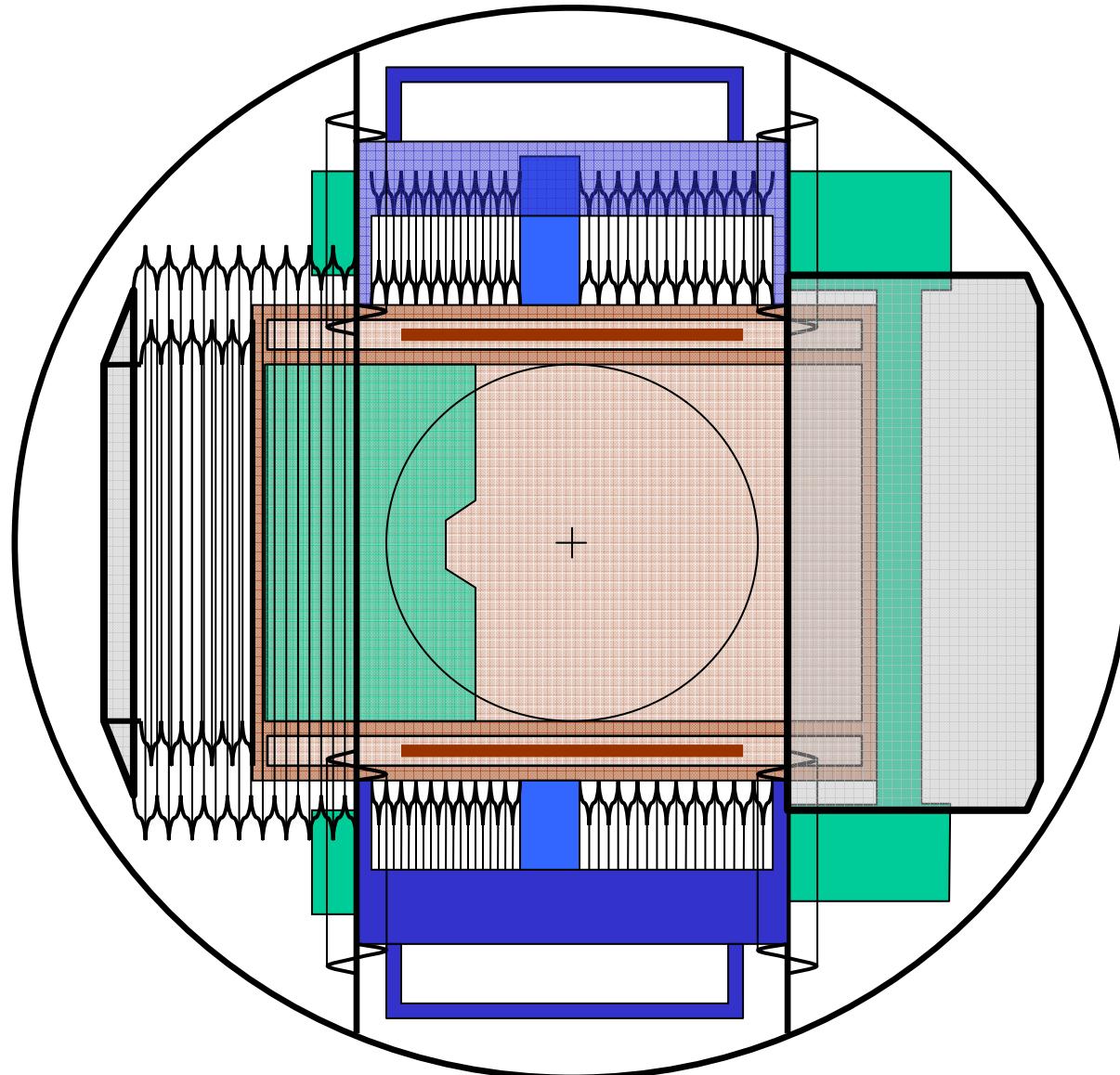
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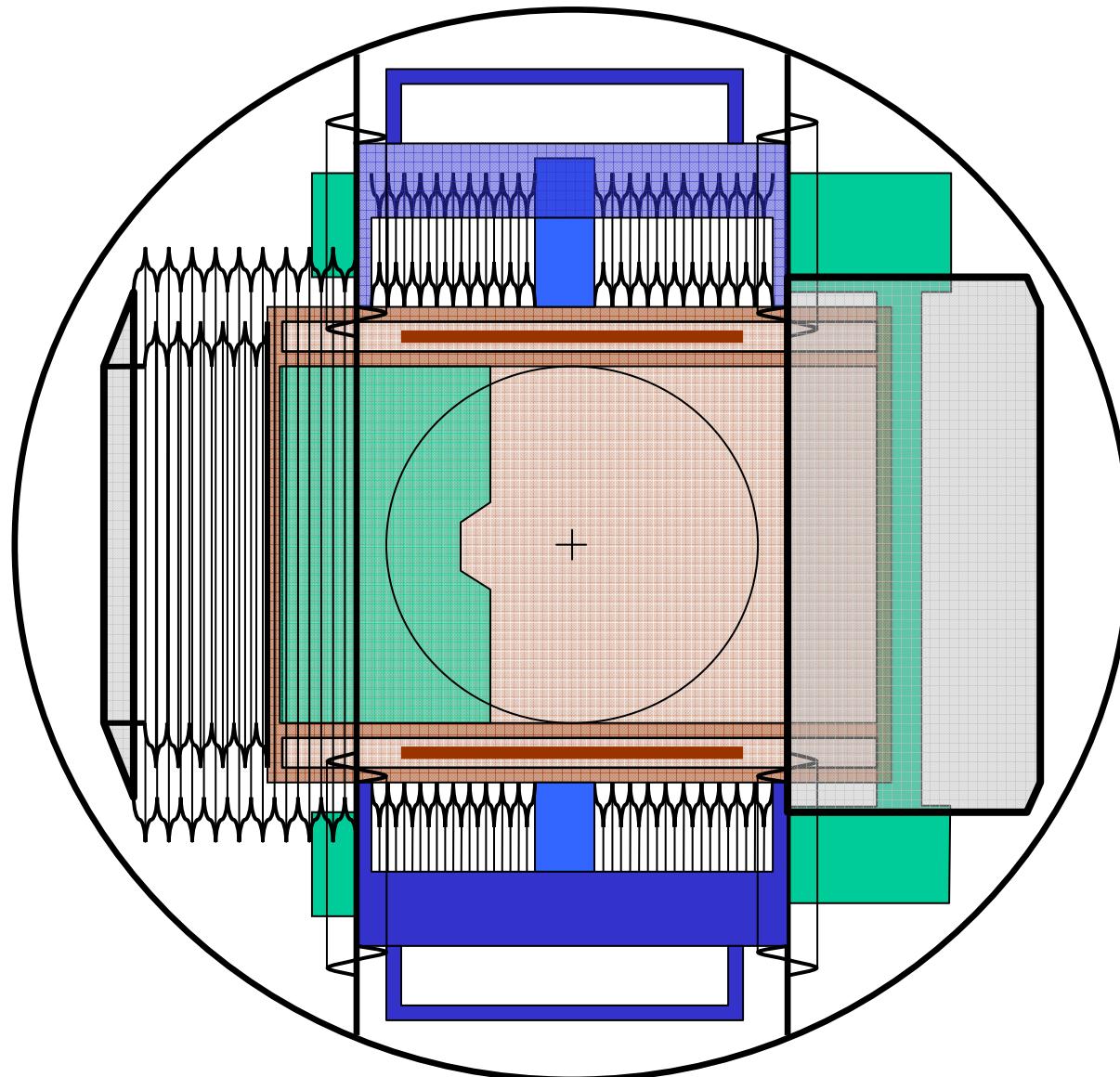
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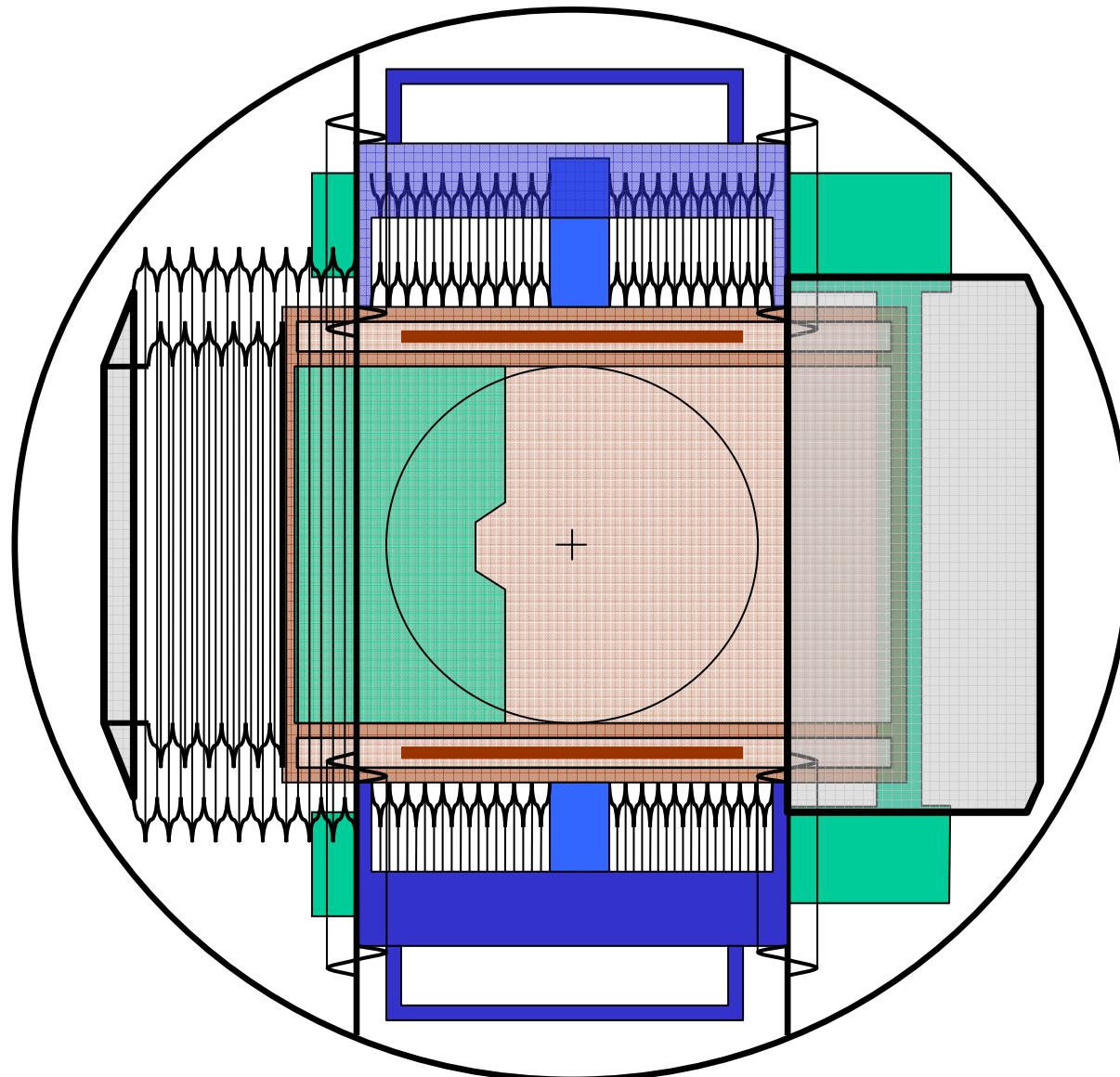
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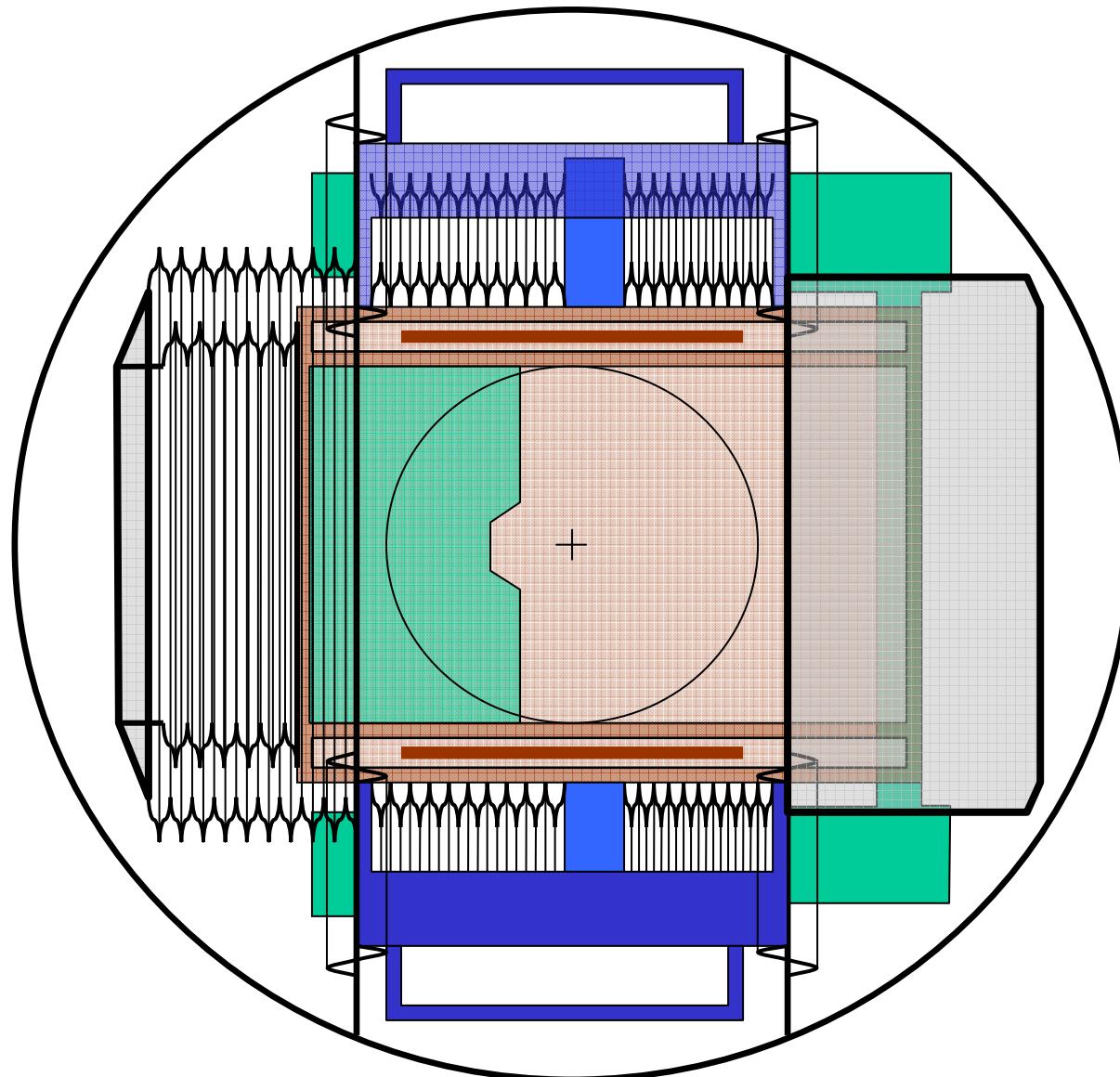
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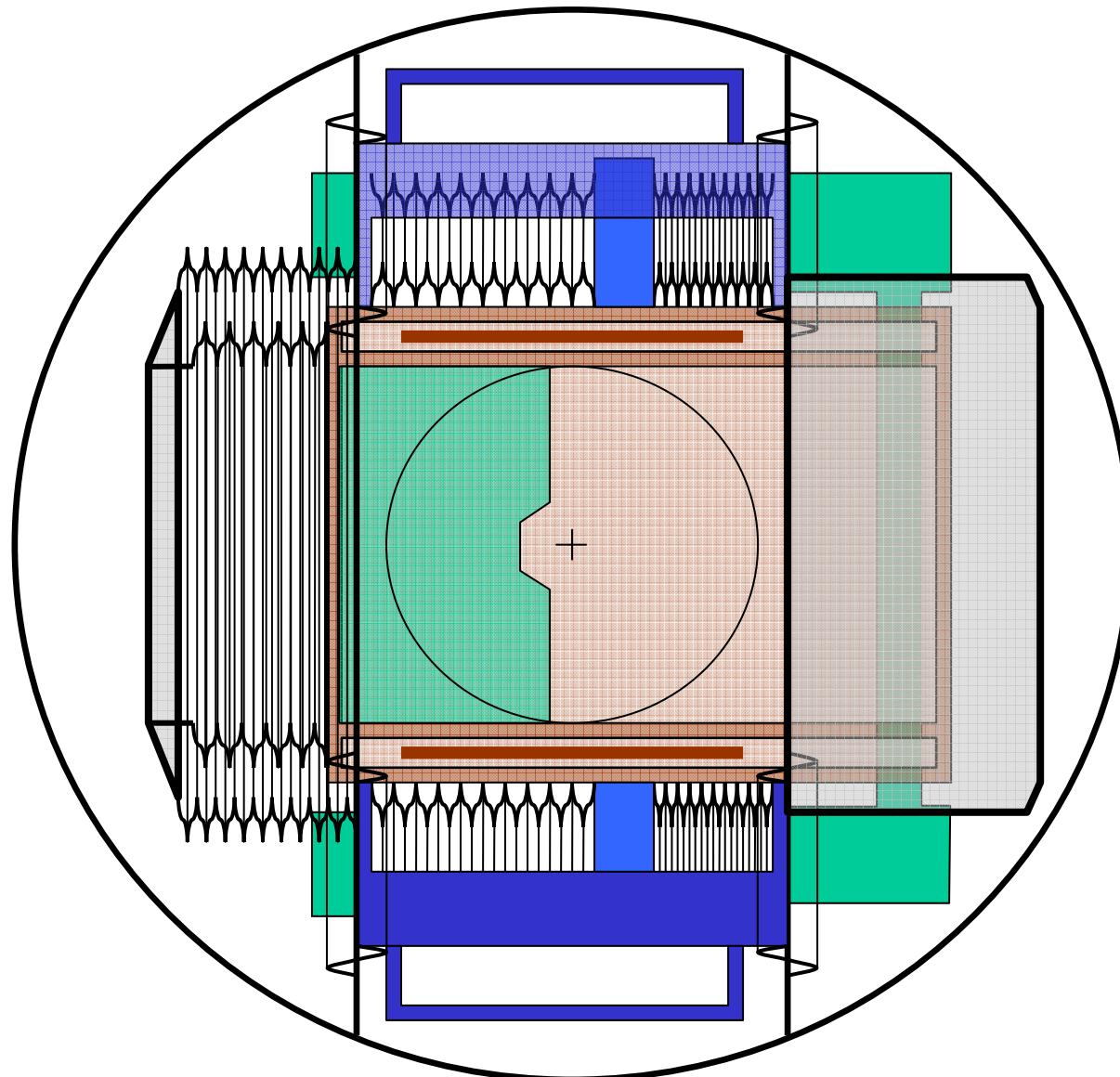
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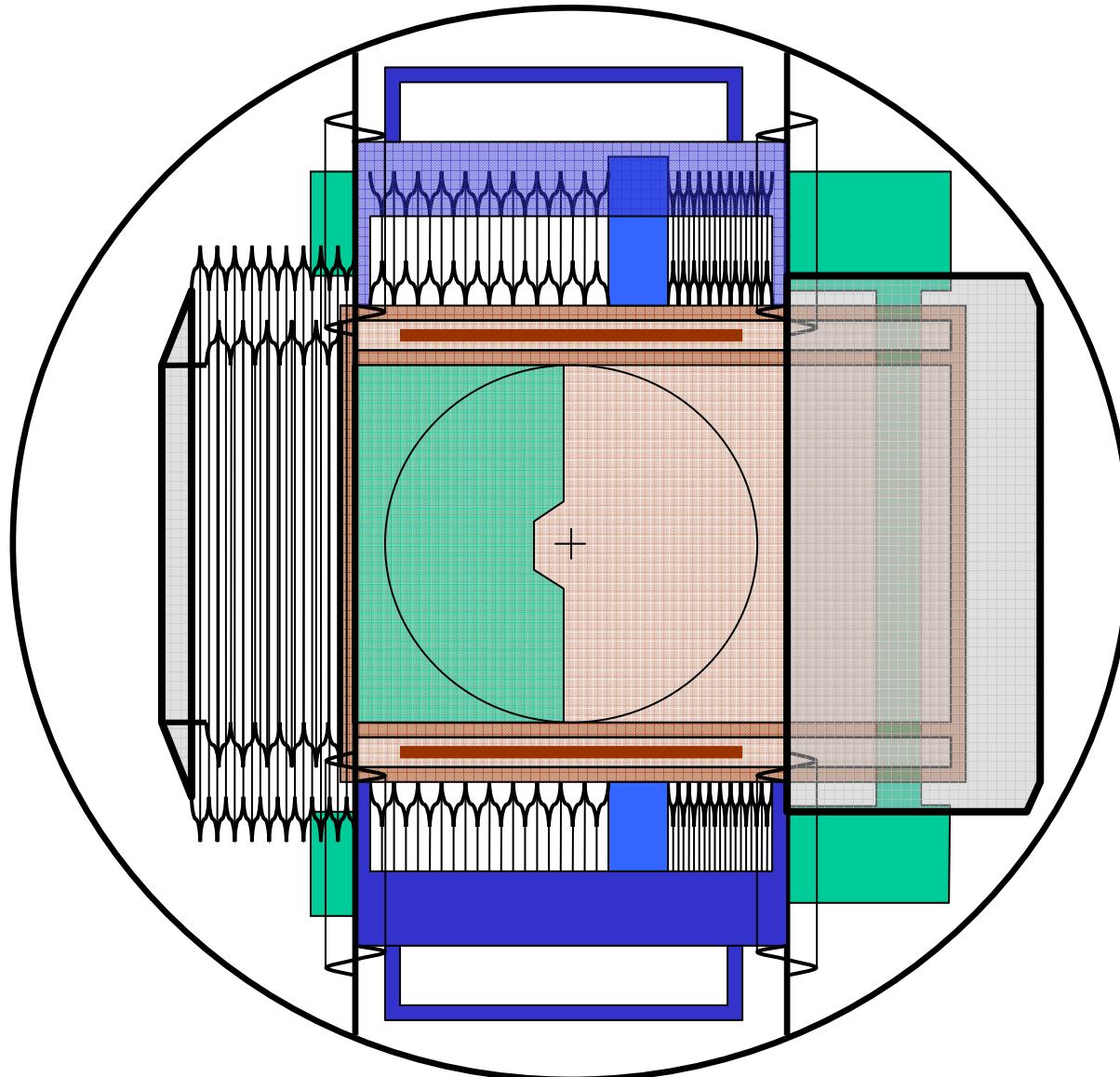
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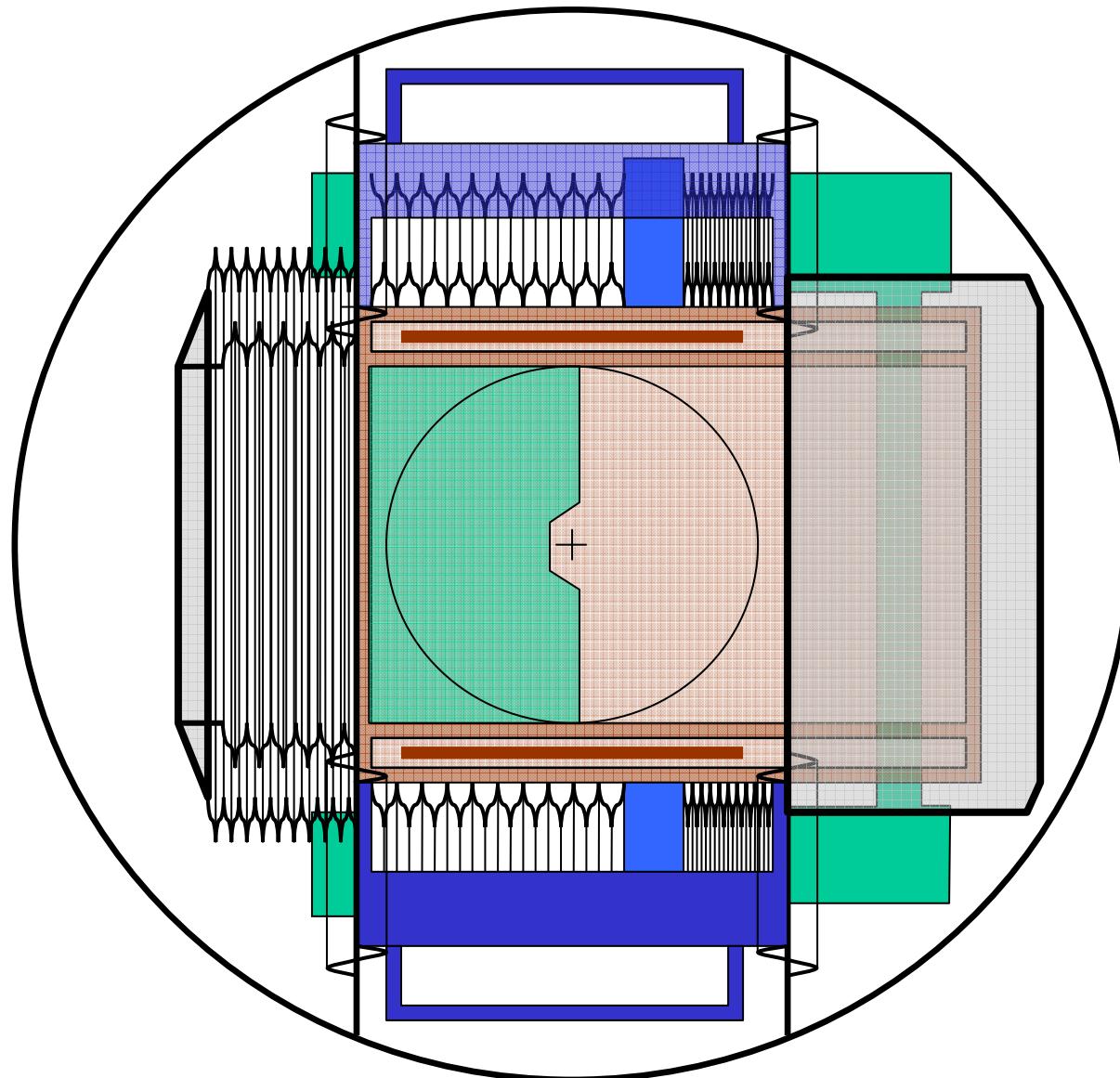
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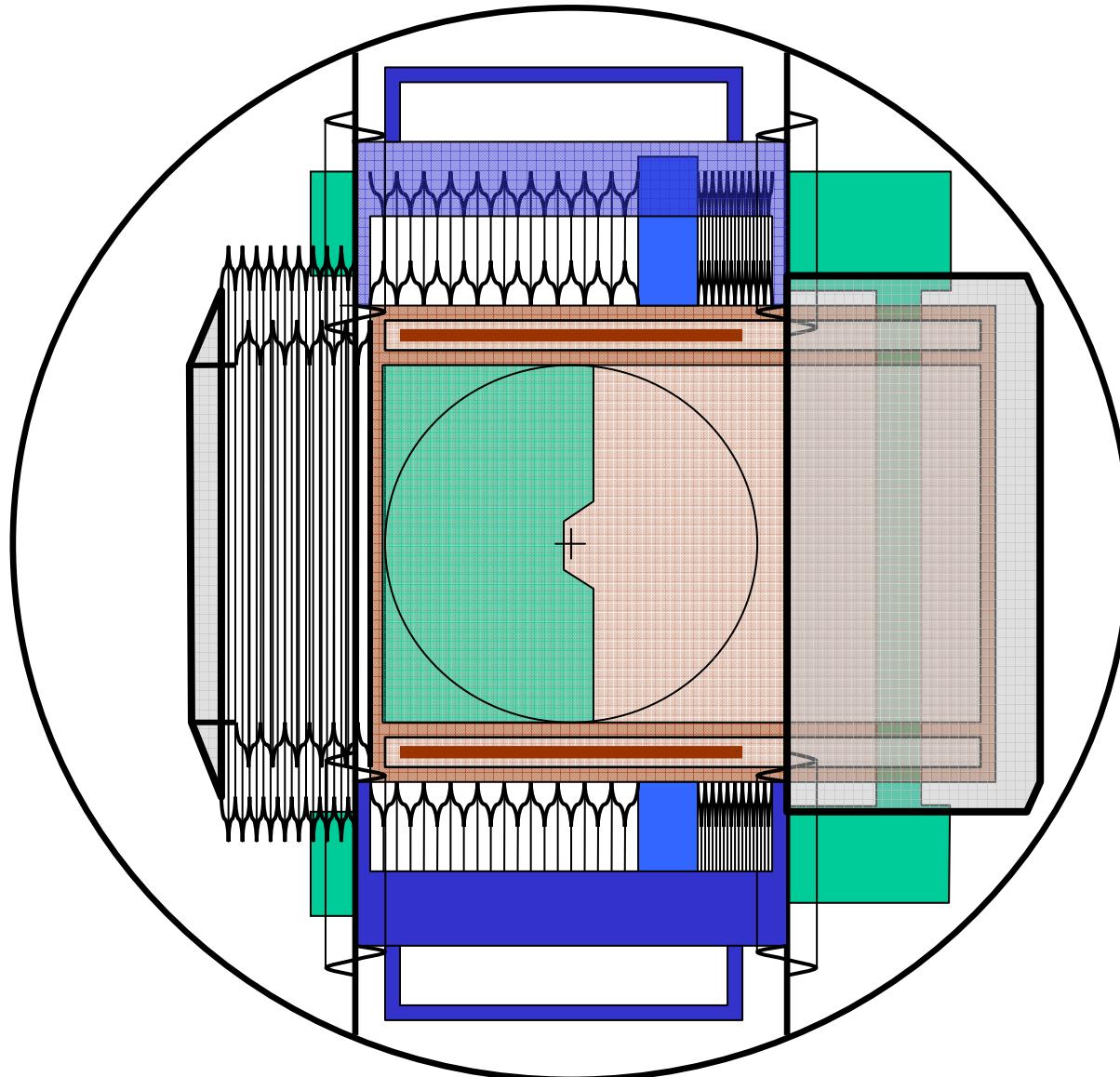
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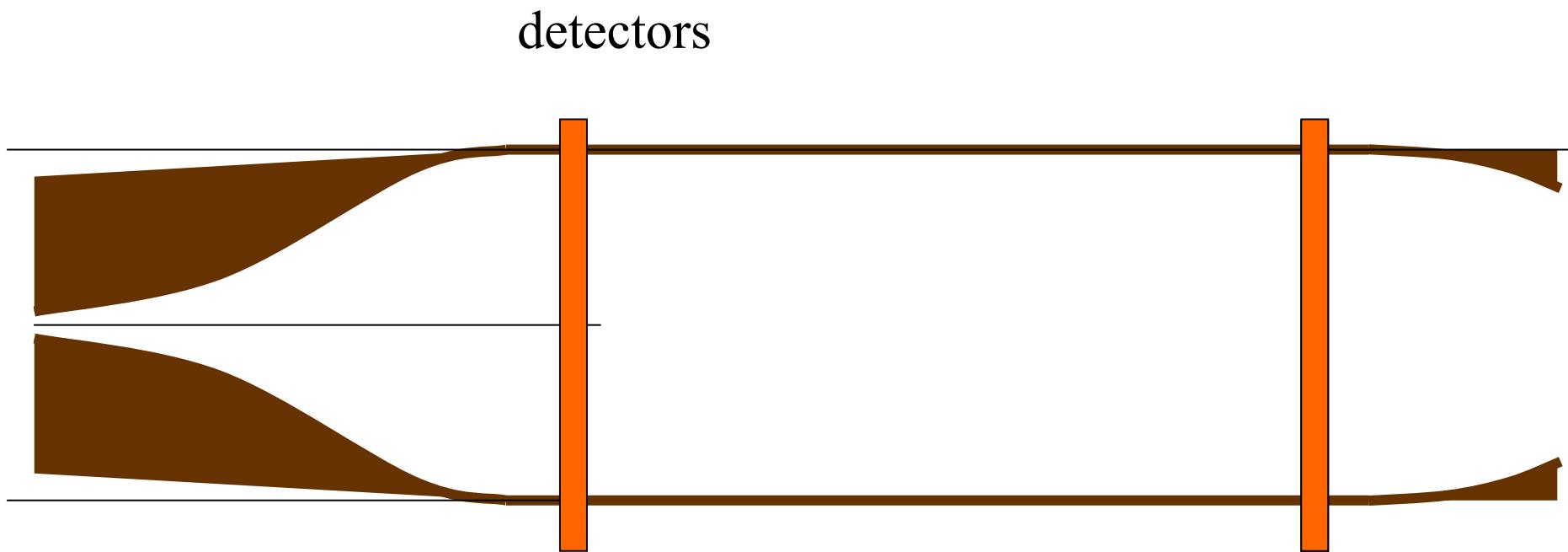
2.1. μ station, Secondary Vacuum Implementation



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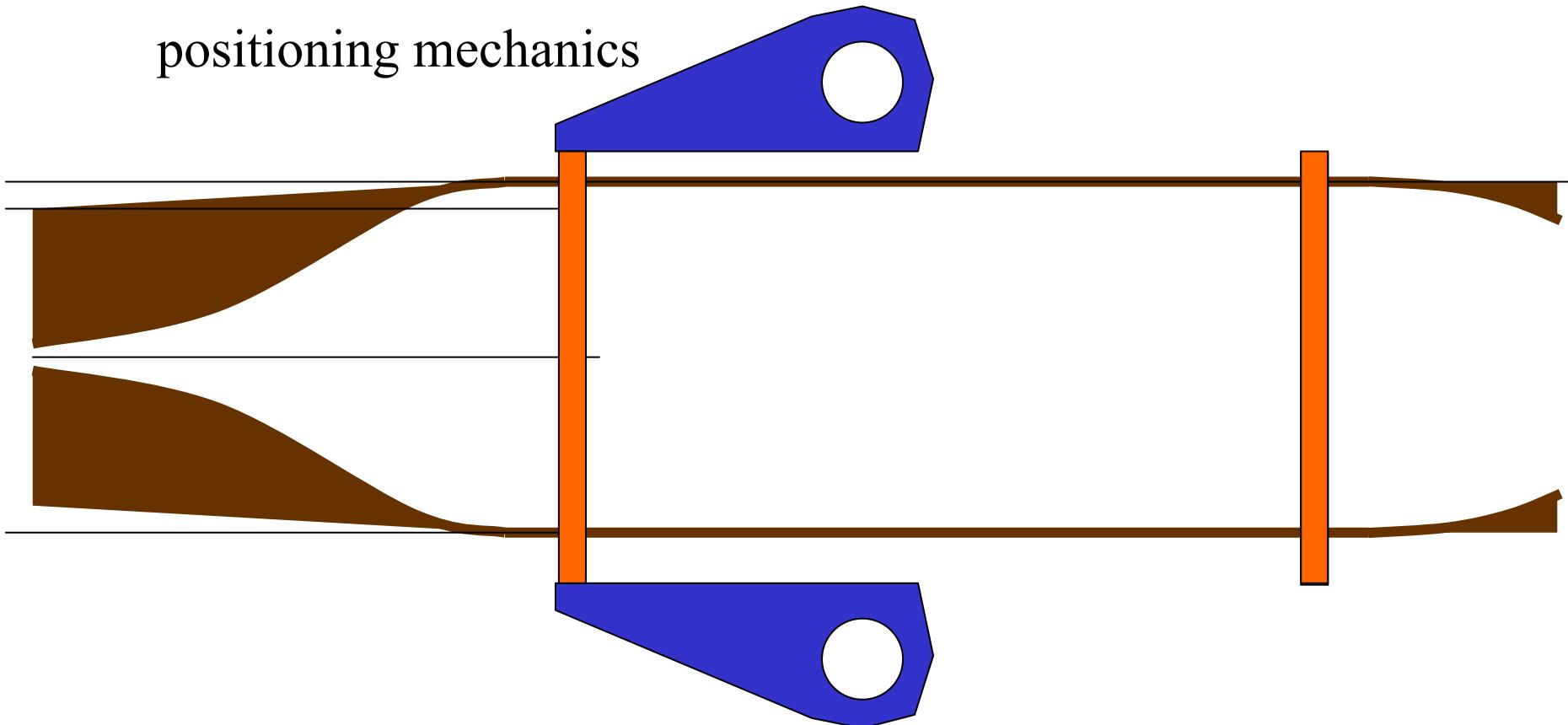


2.1. μ station, Secondary Vacuum Implementation



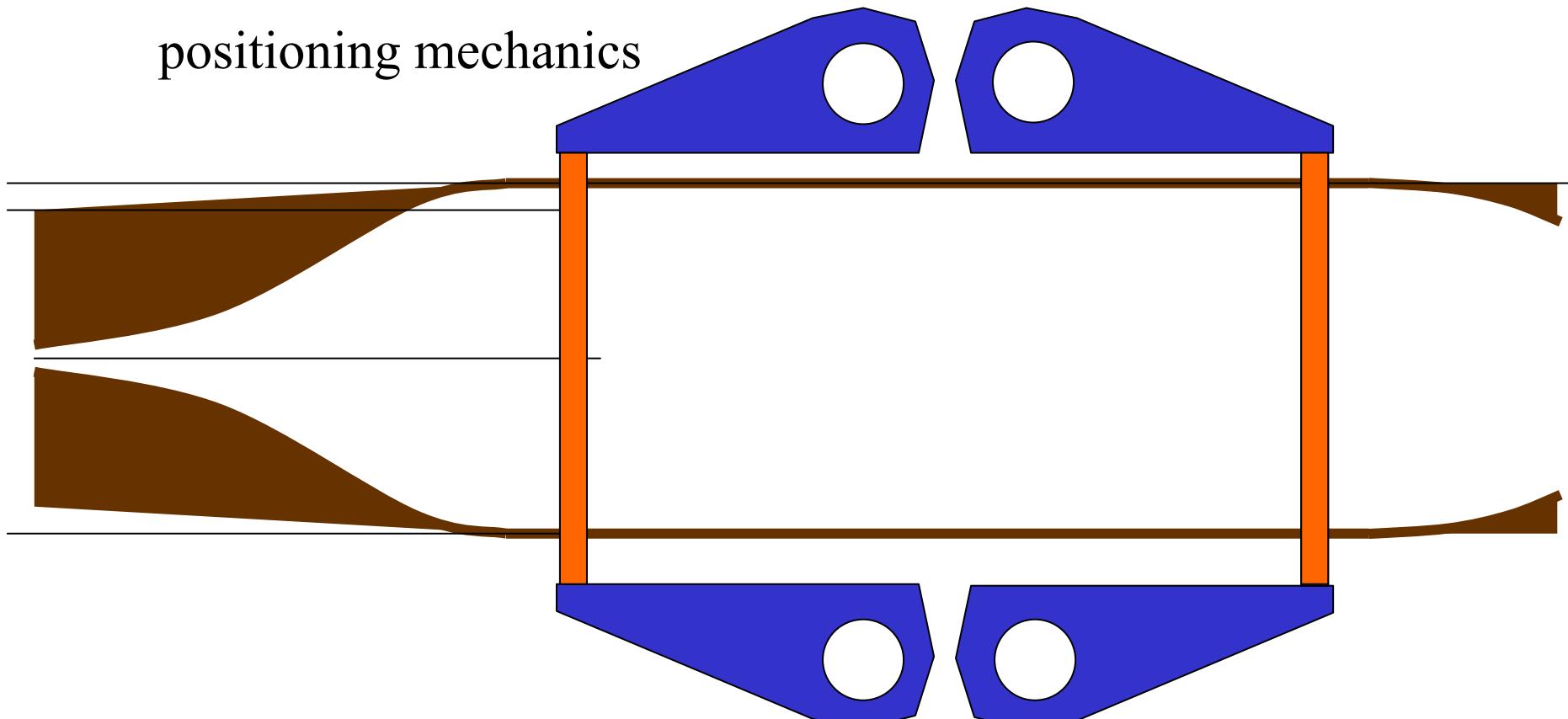
2.1. μ station, Secondary Vacuum Implementation

positioning mechanics

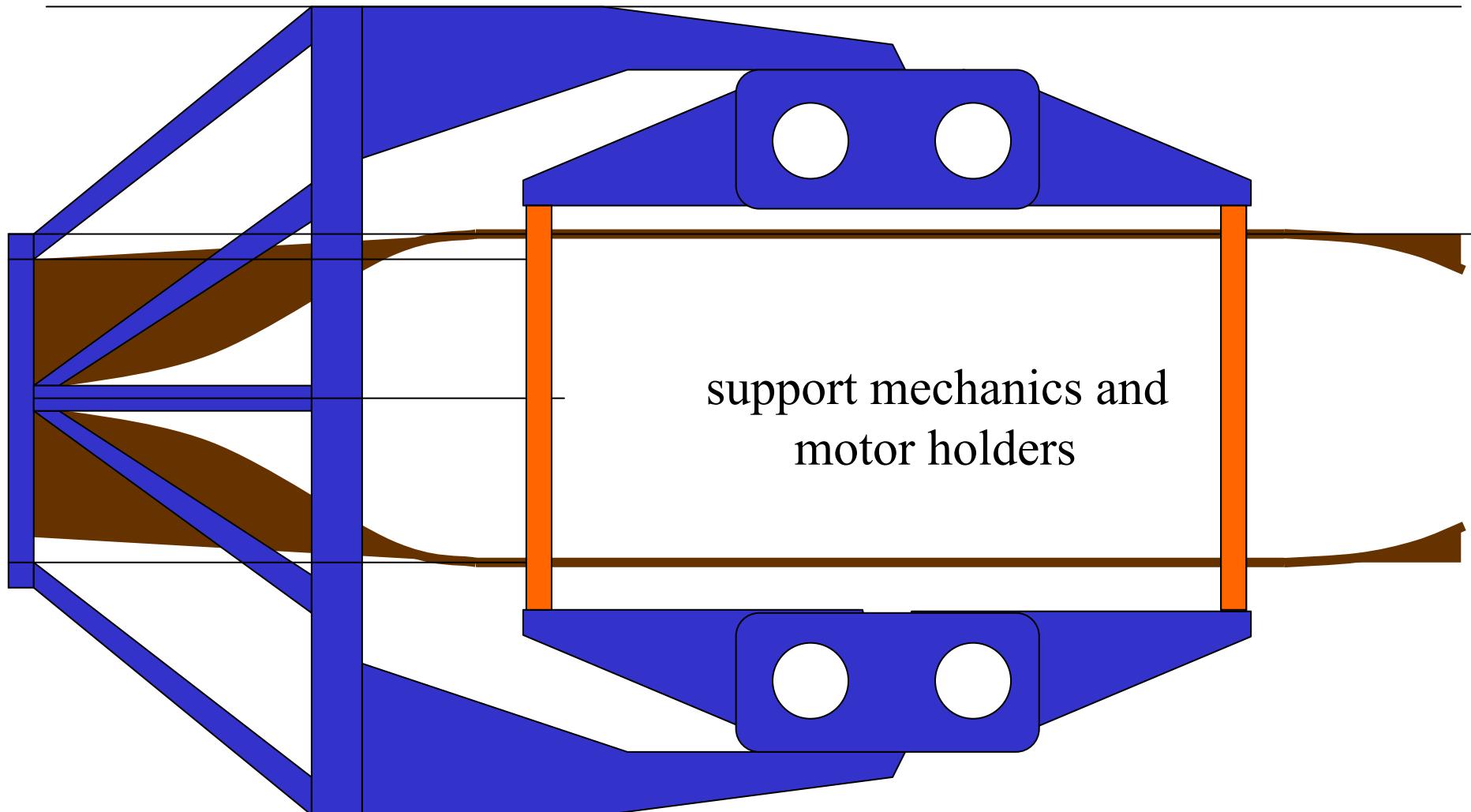


2.1. μ station, Secondary Vacuum Implementation

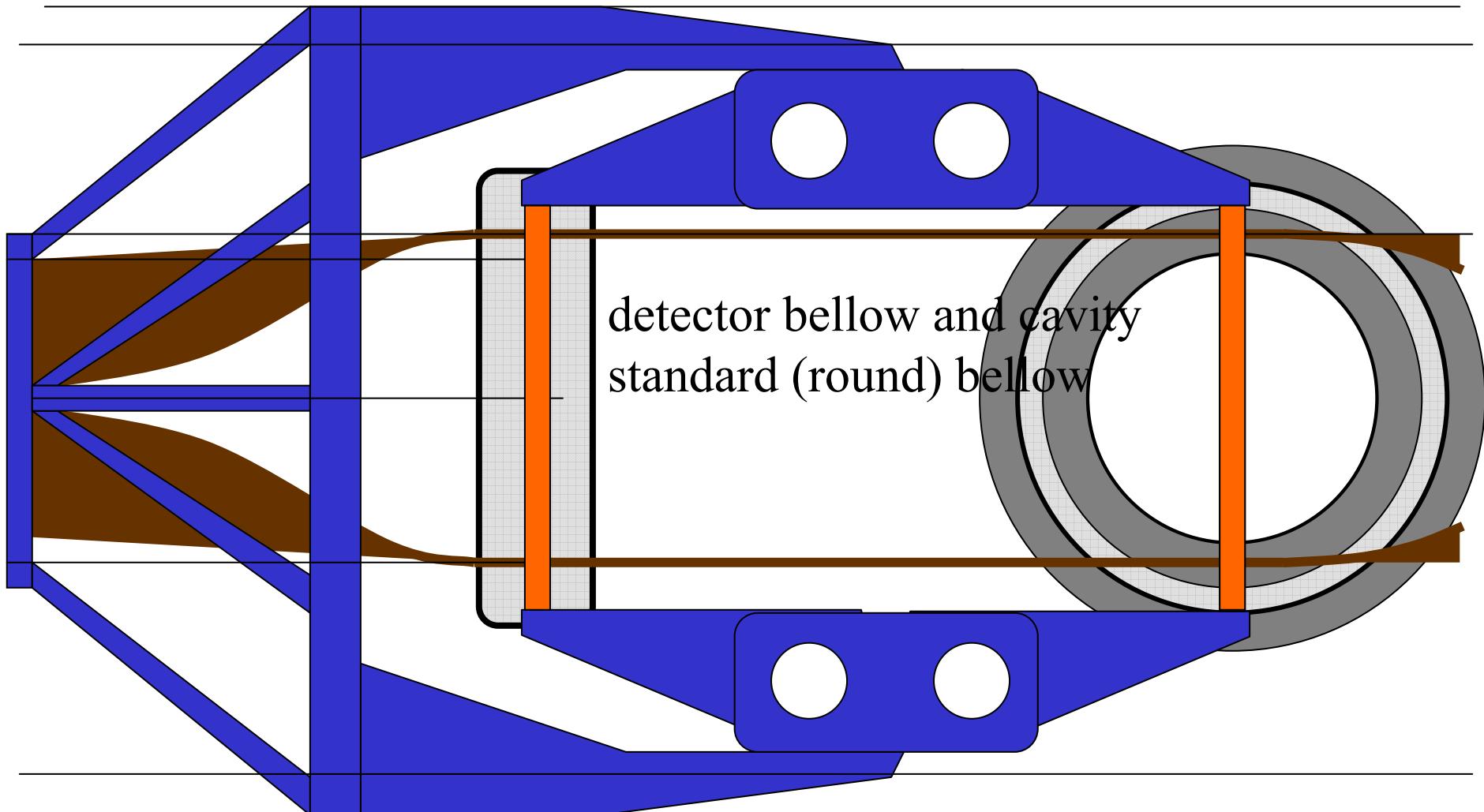
positioning mechanics



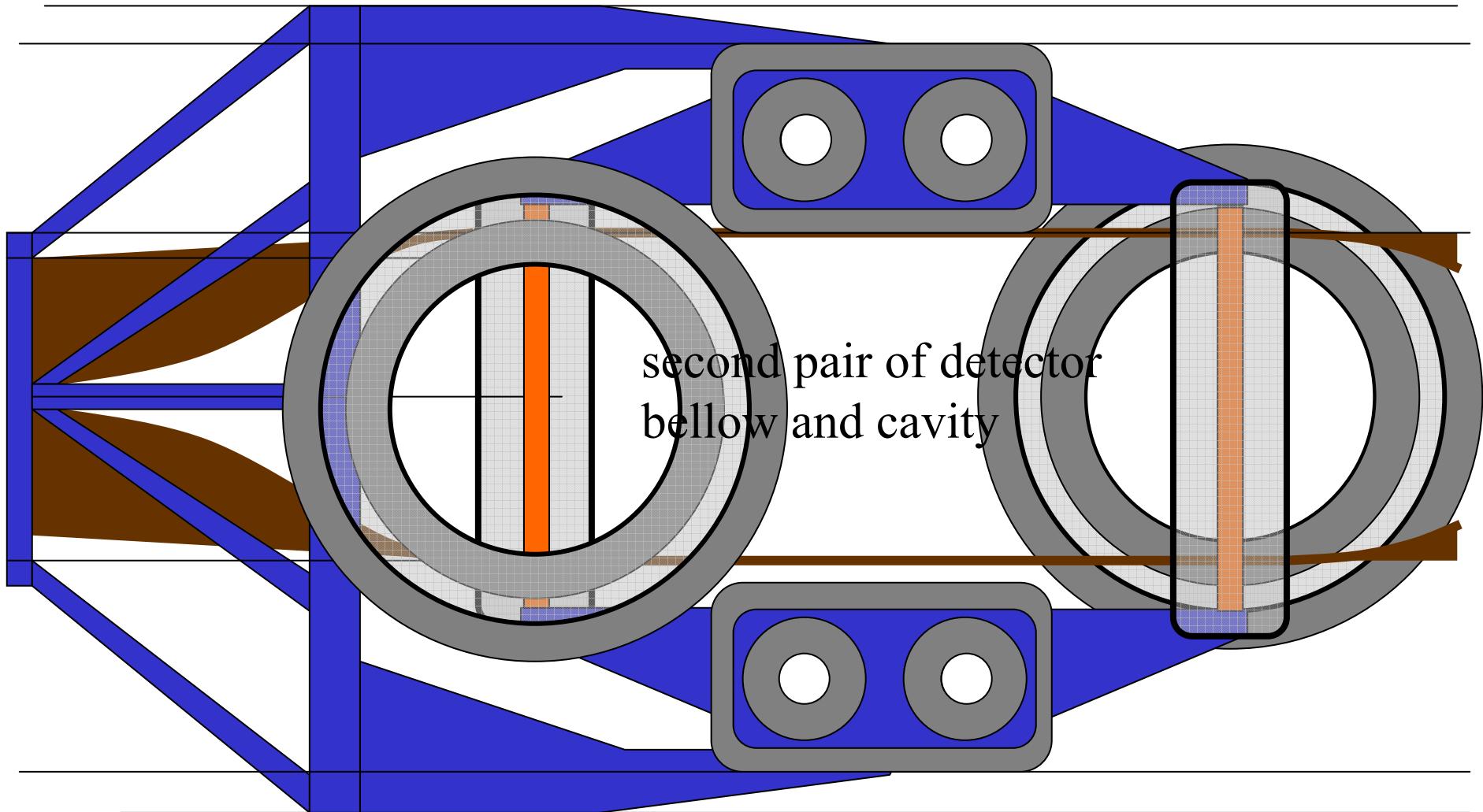
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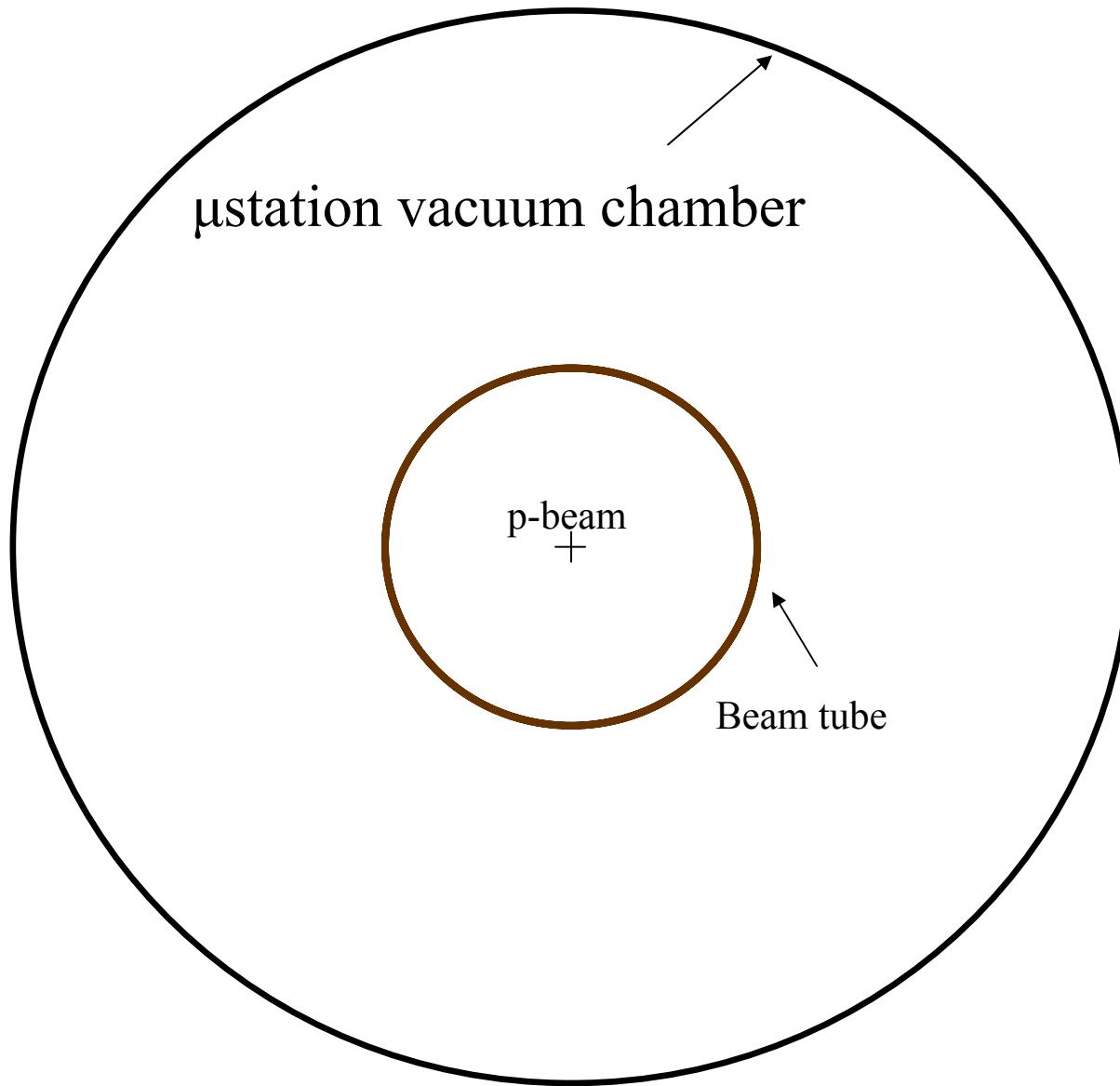
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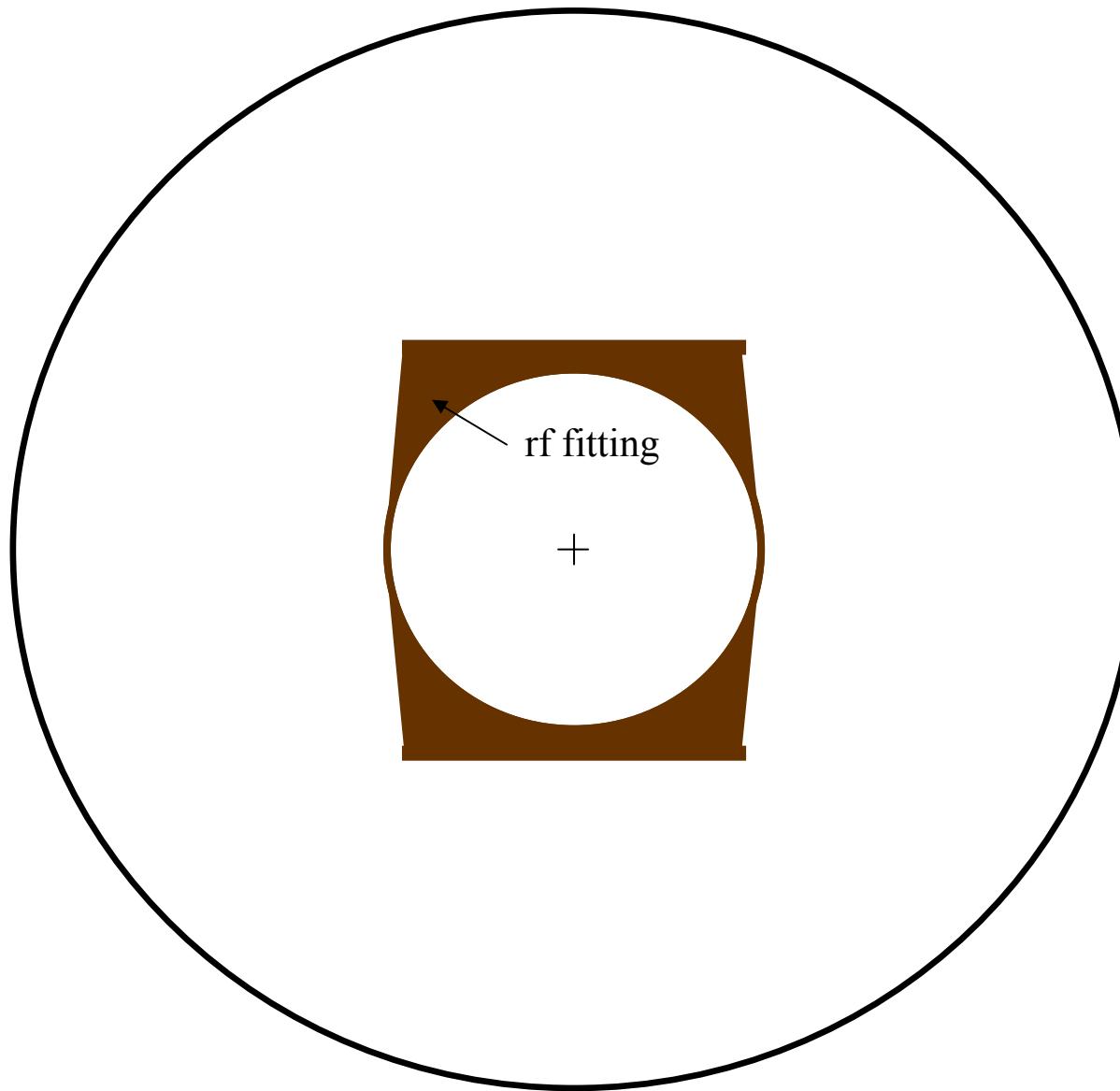
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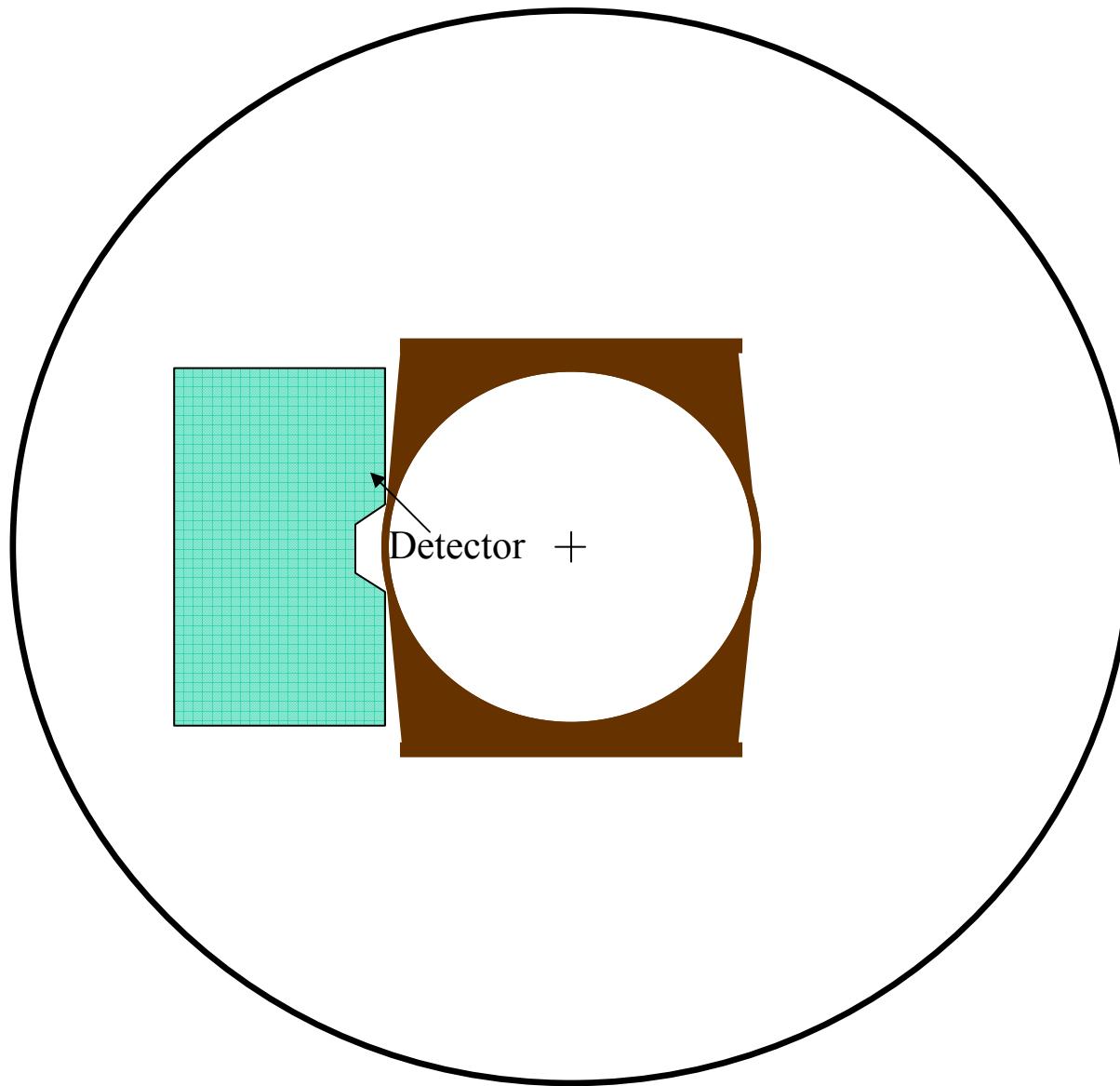
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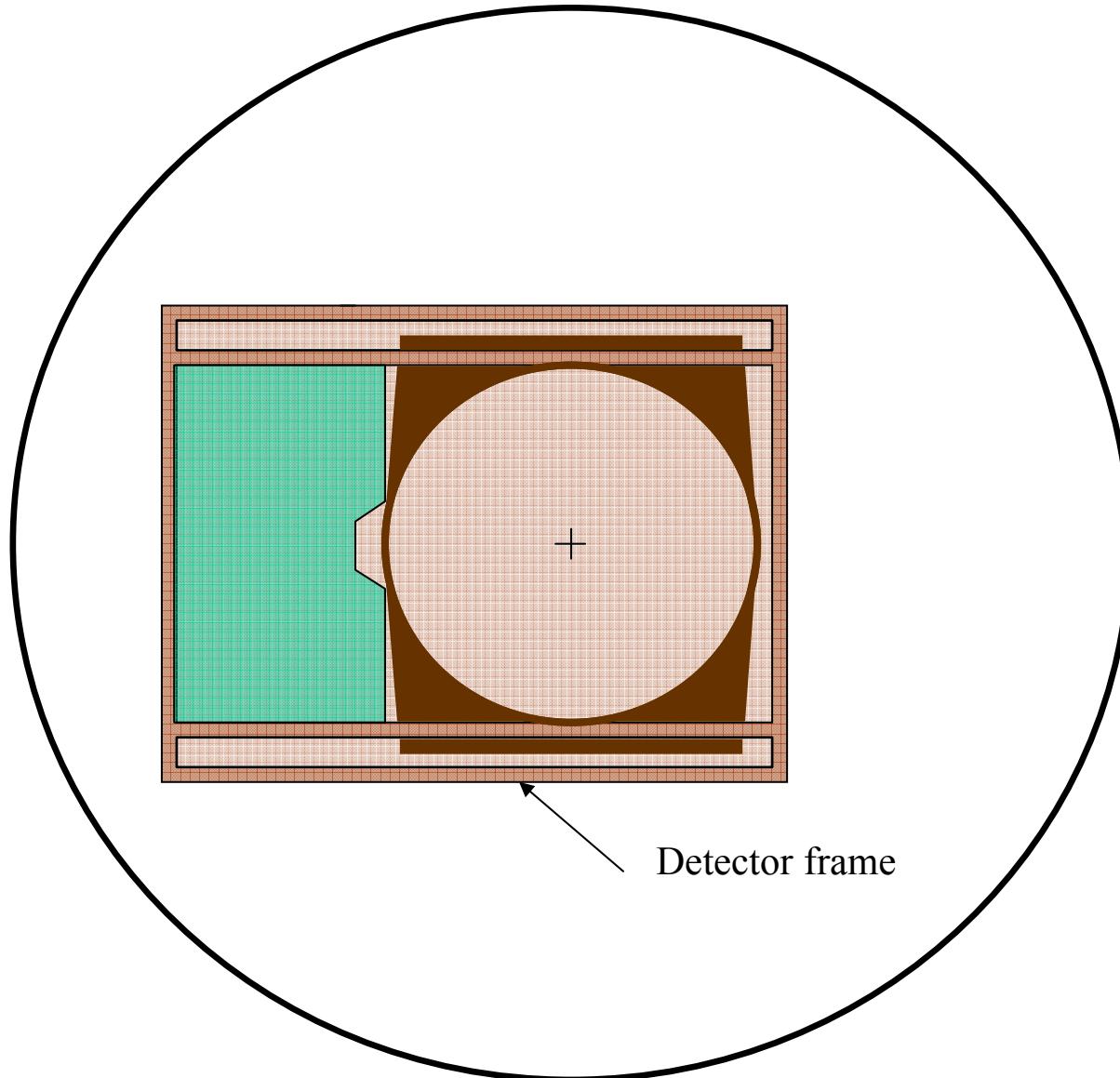
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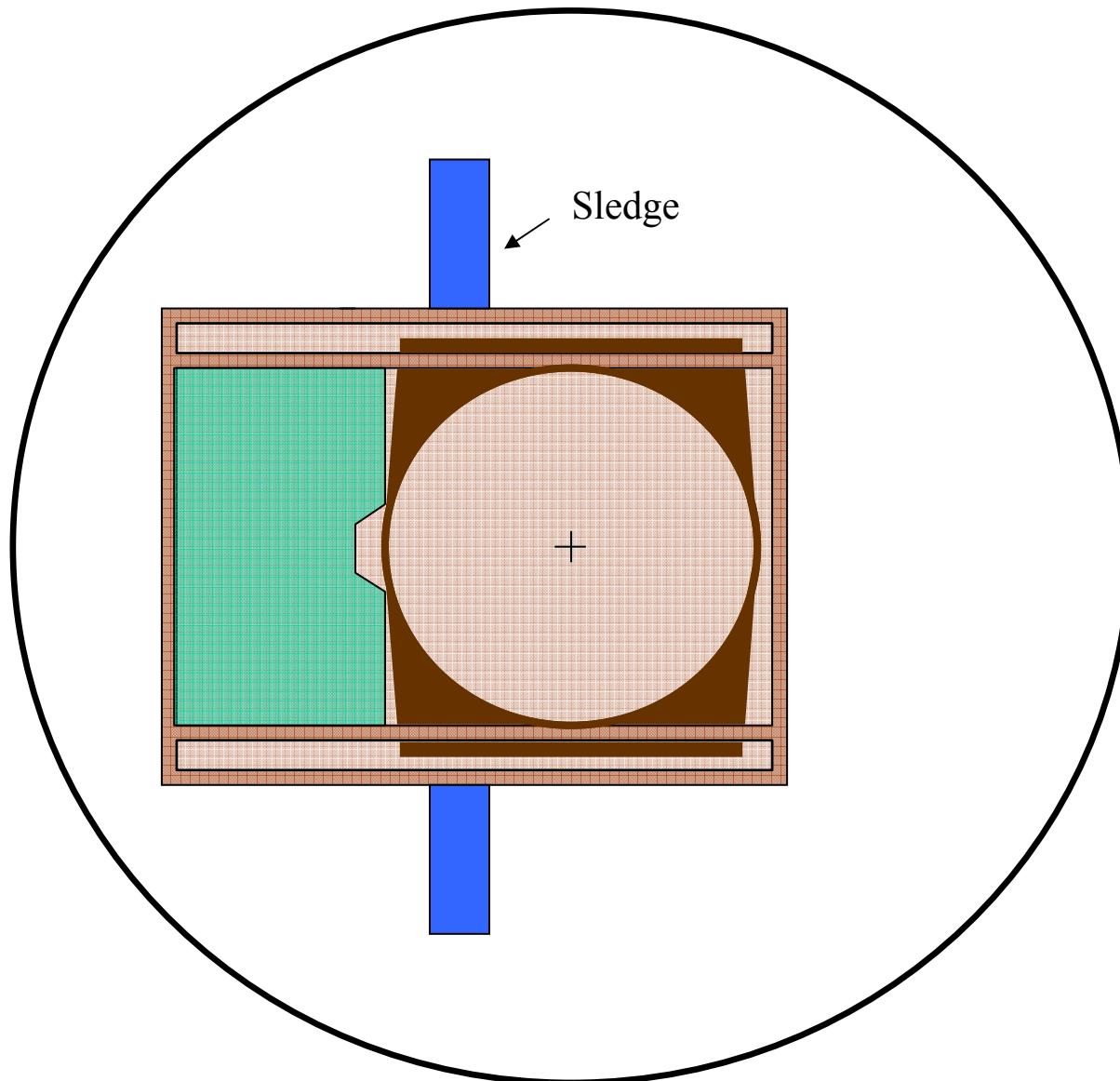
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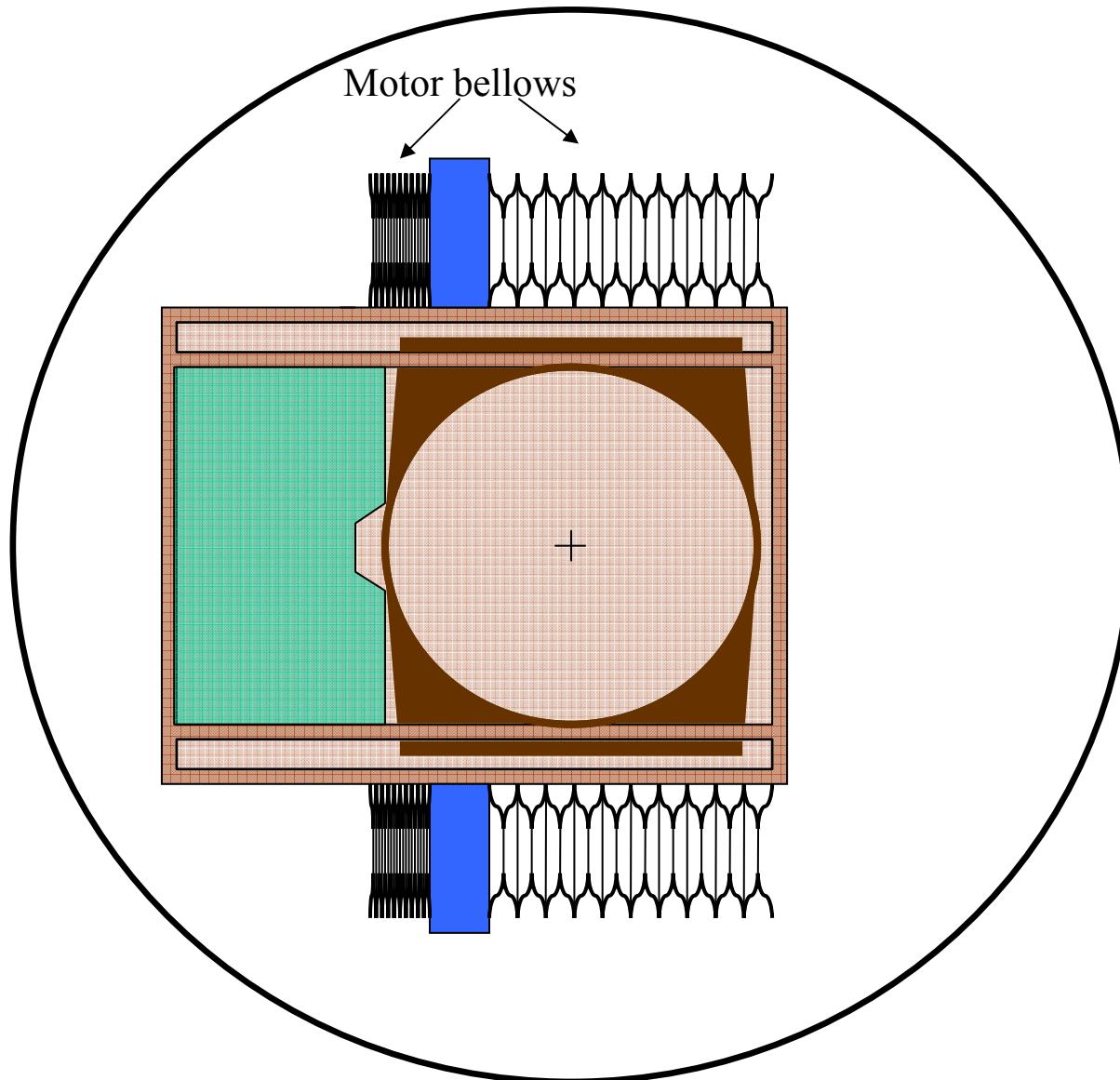
2.1. μ station, Secondary Vacuum Implementation



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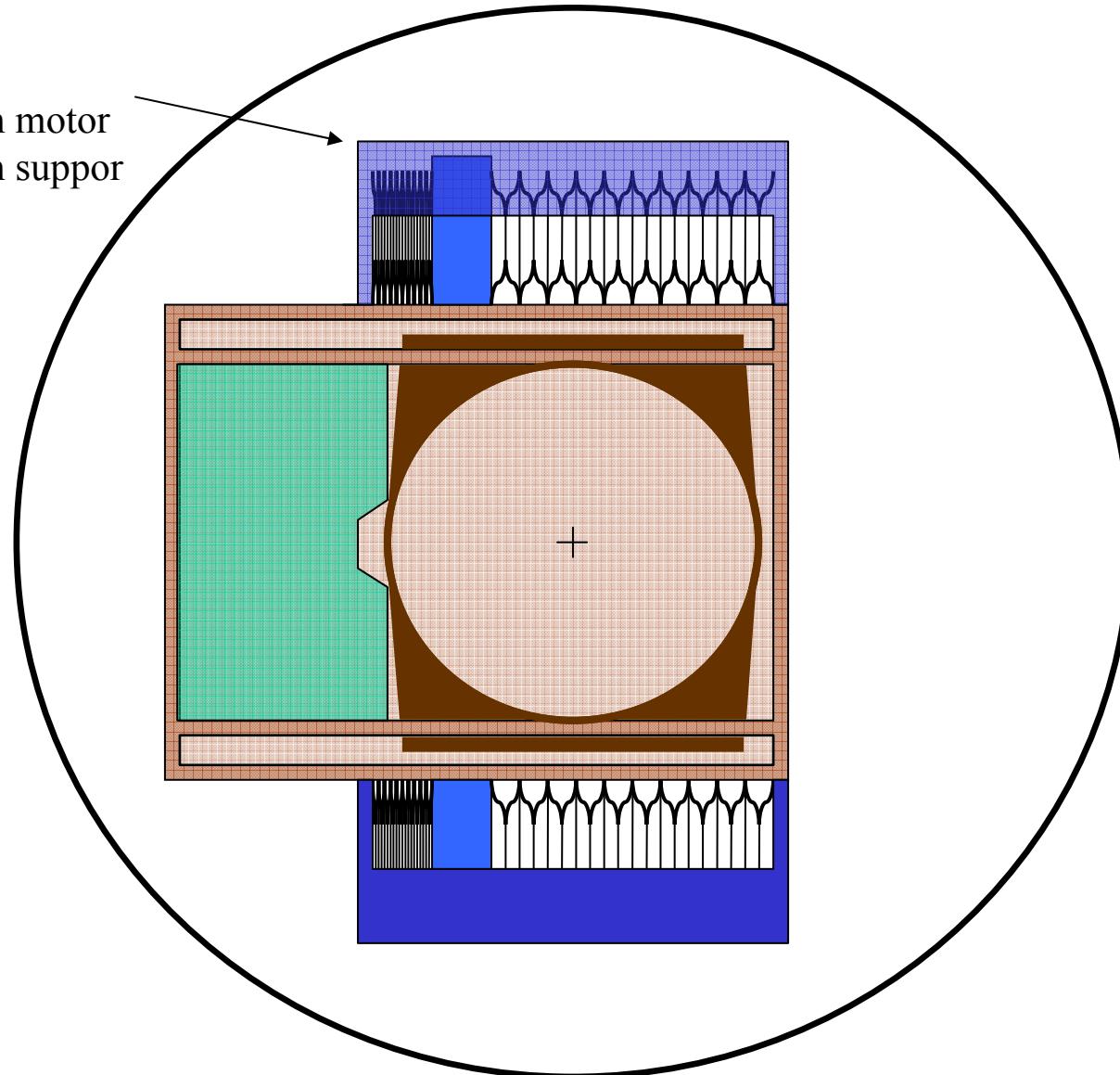
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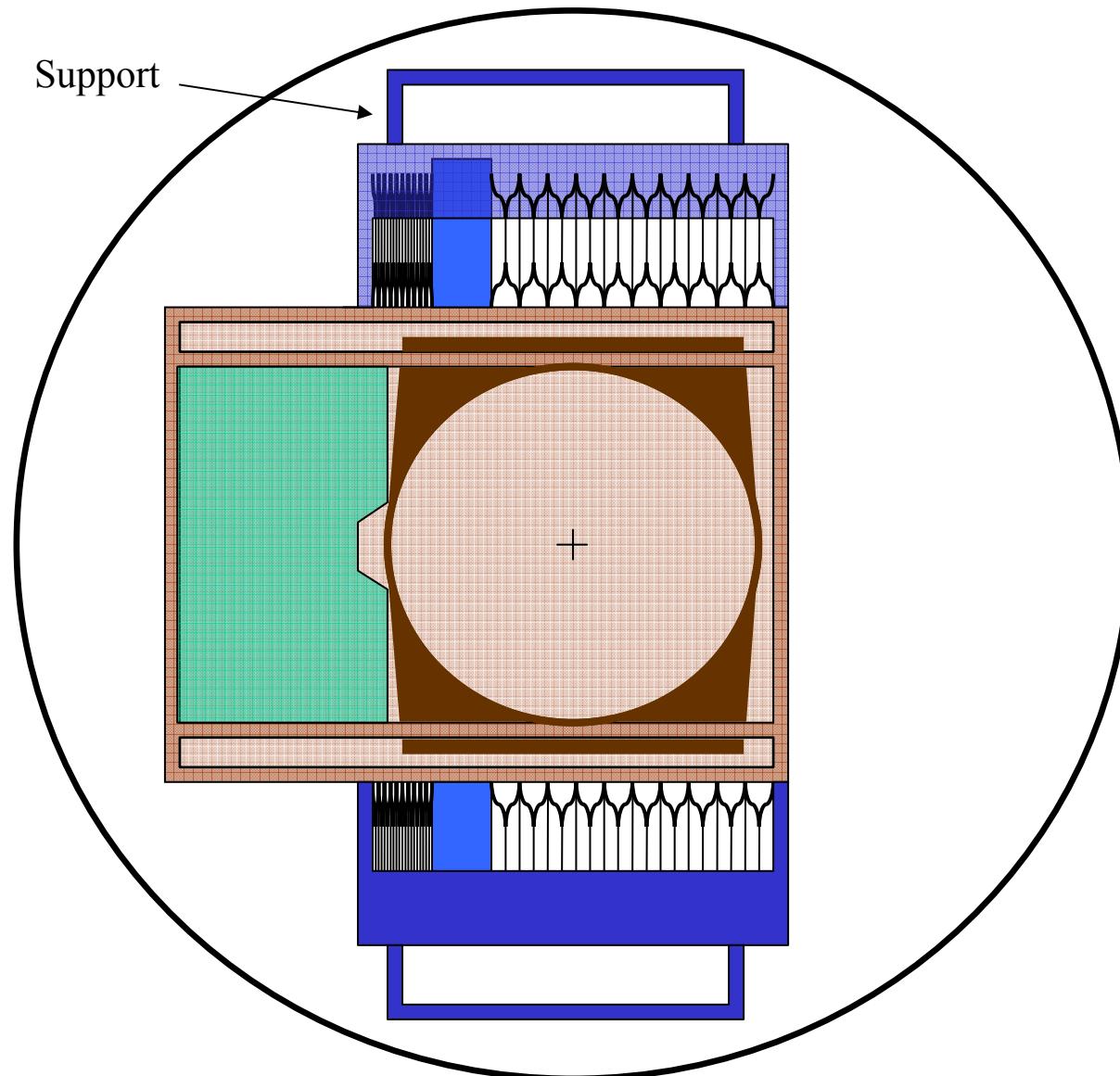
2.1. μ station, Secondary Vacuum Implementation

Motor holder

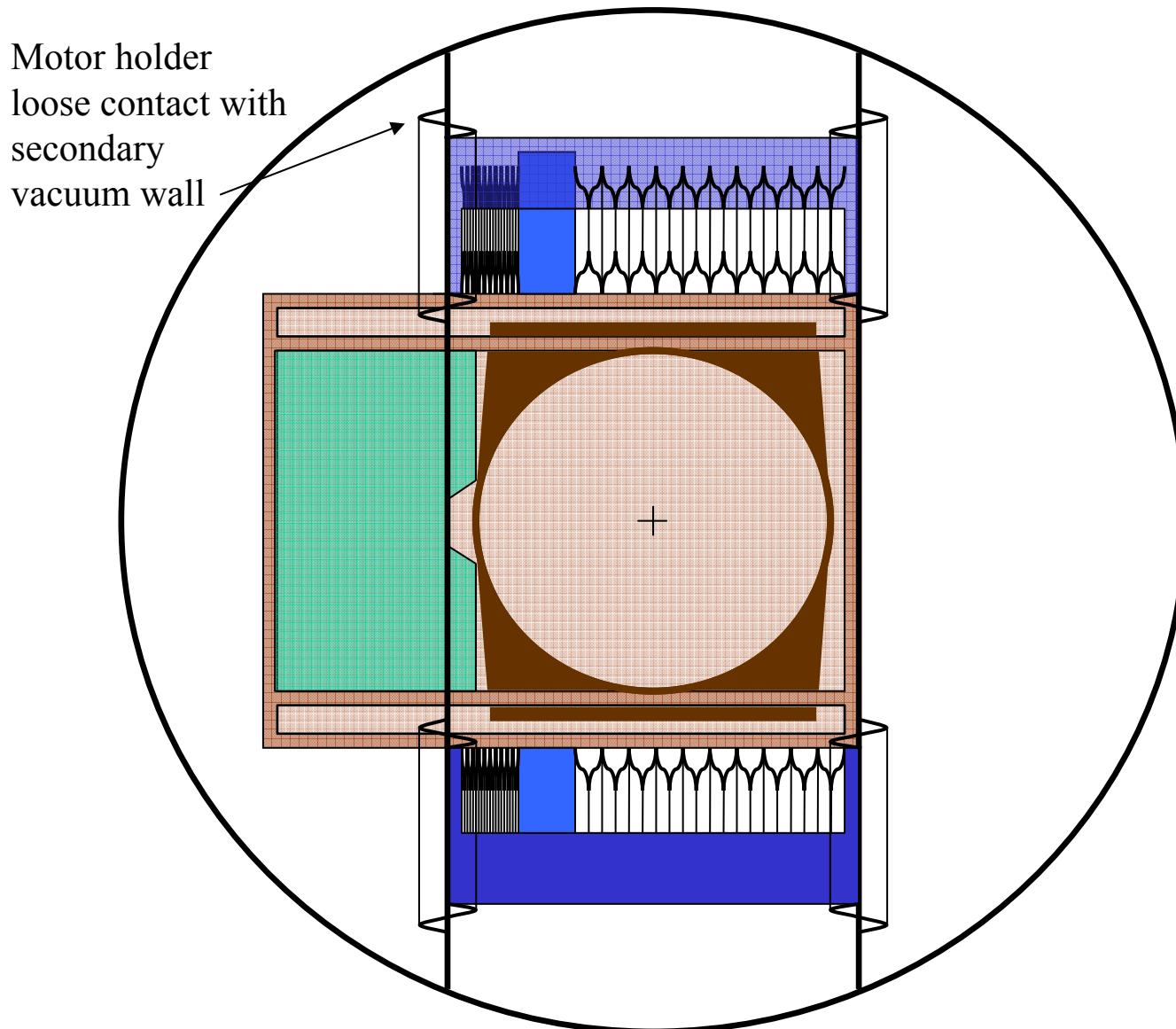
- stiff contact with motor
- stiff contact with support



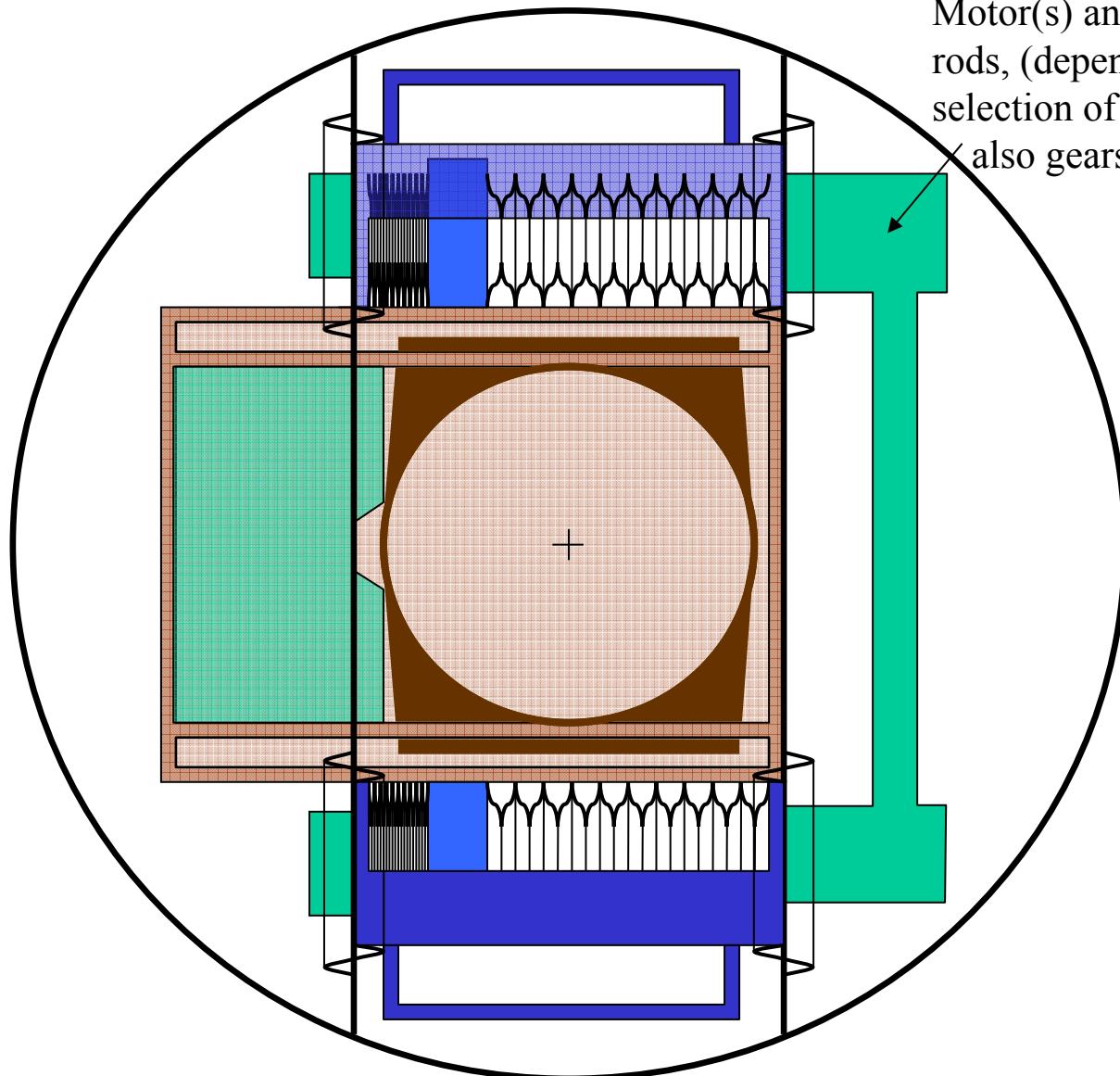
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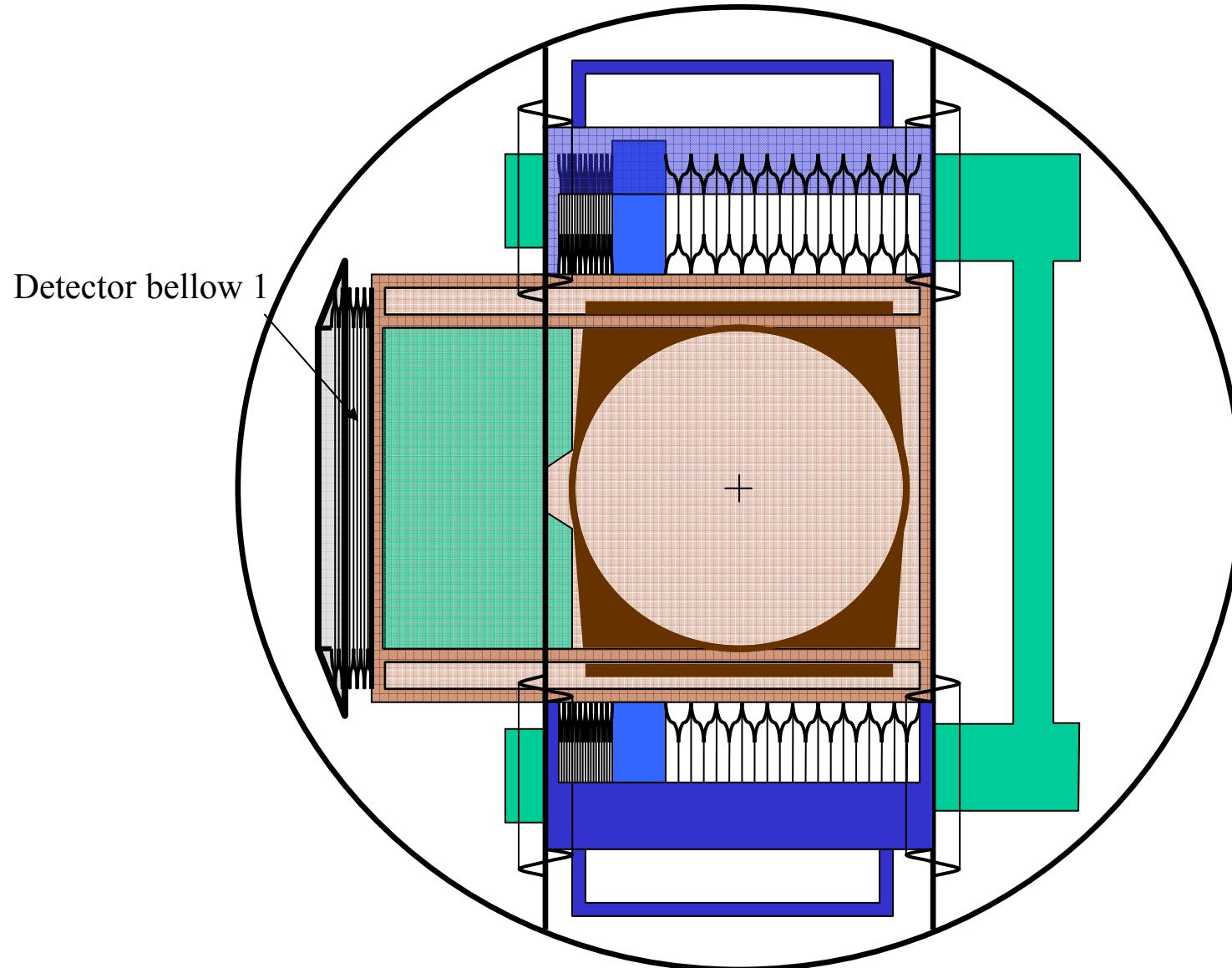
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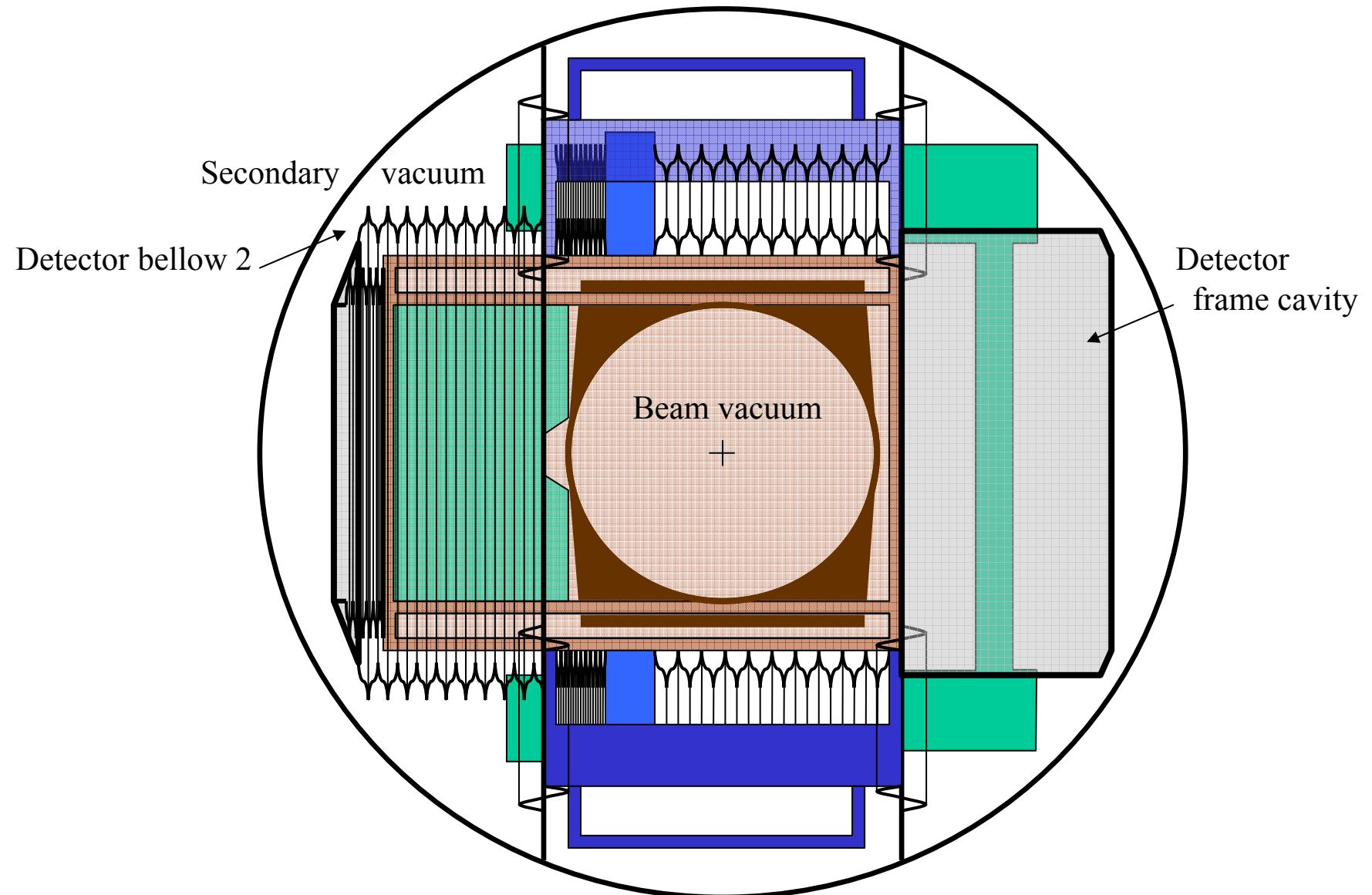
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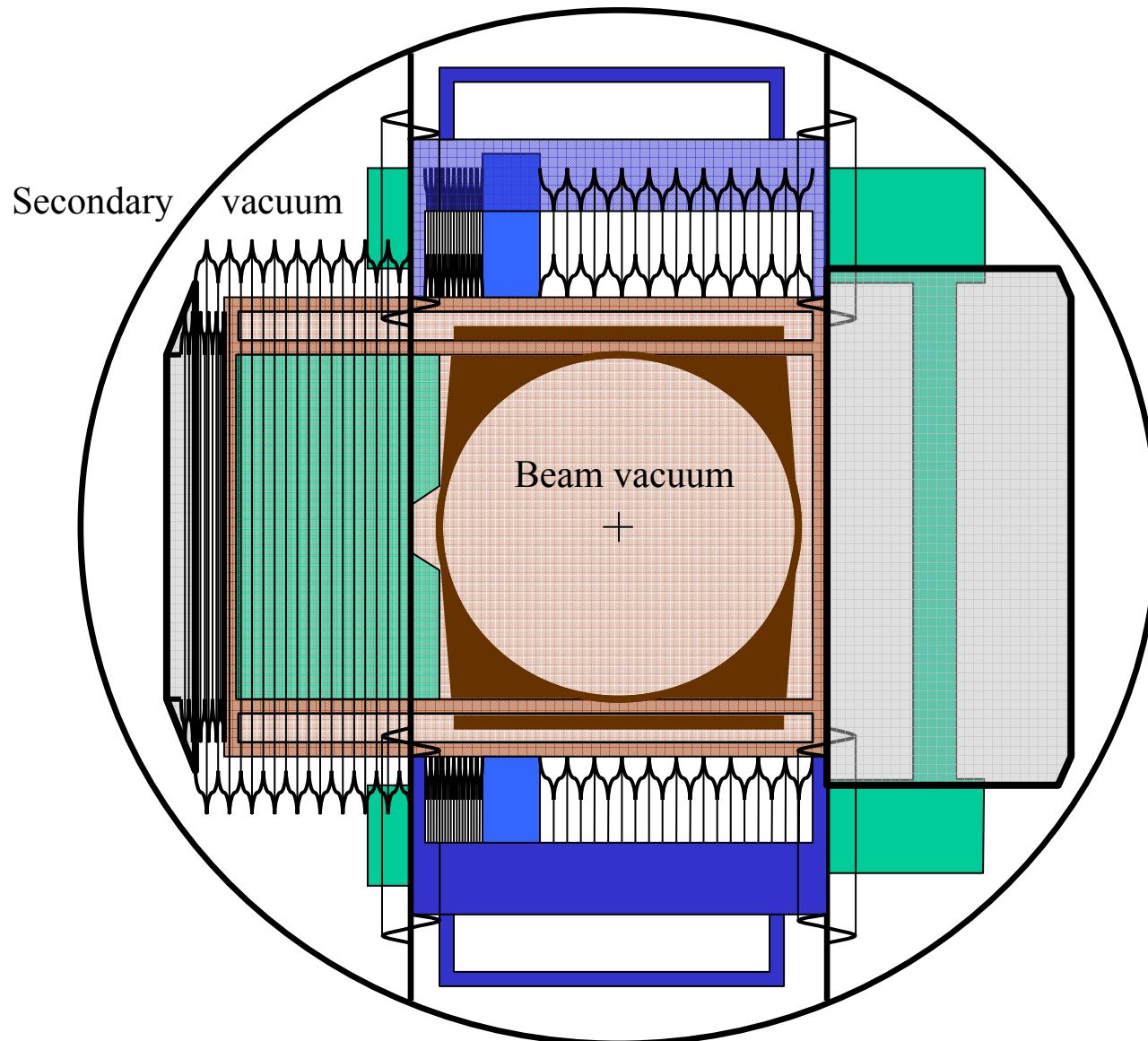
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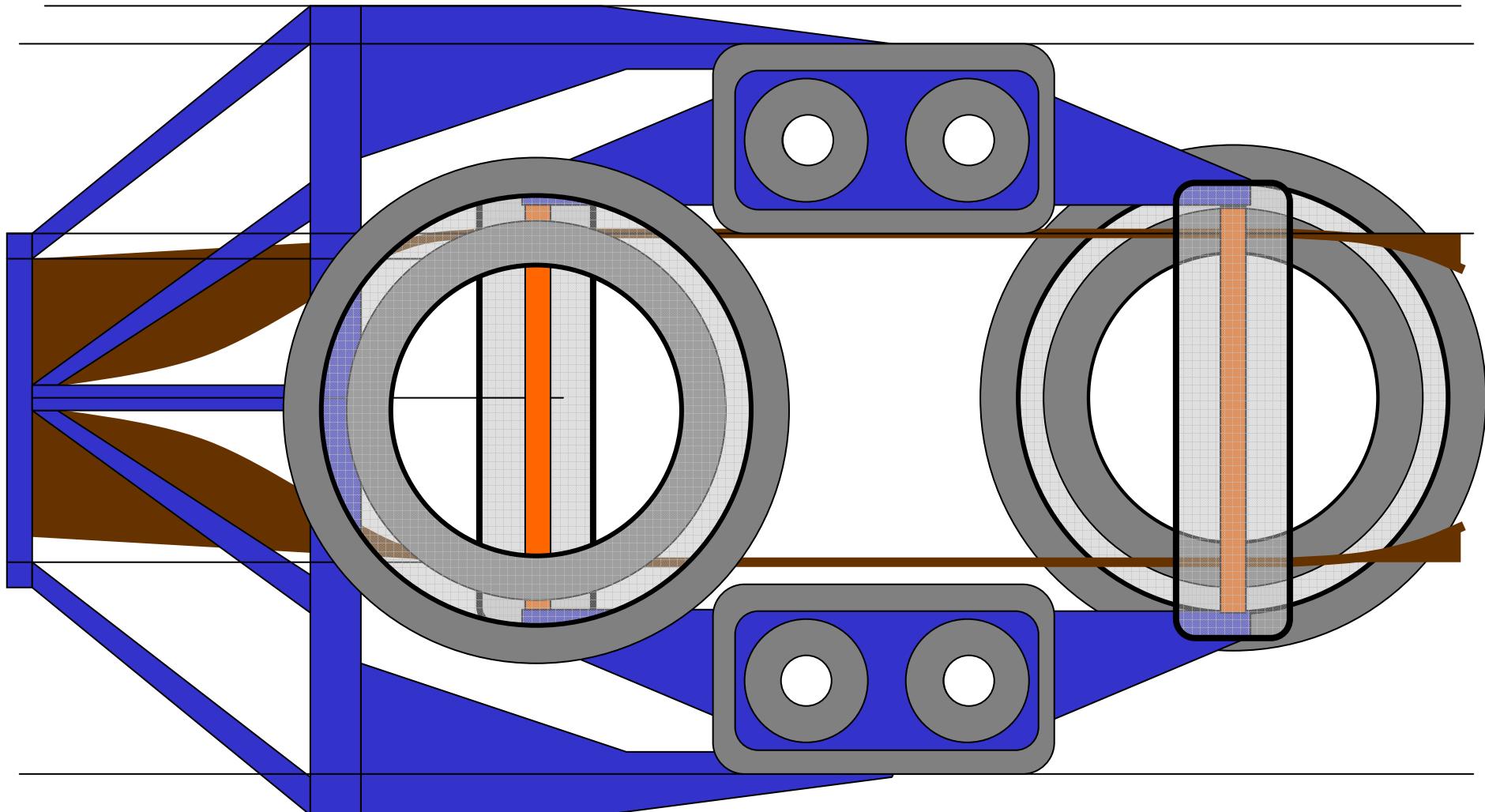
2.1. μ station, Secondary Vacuum Implementation



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